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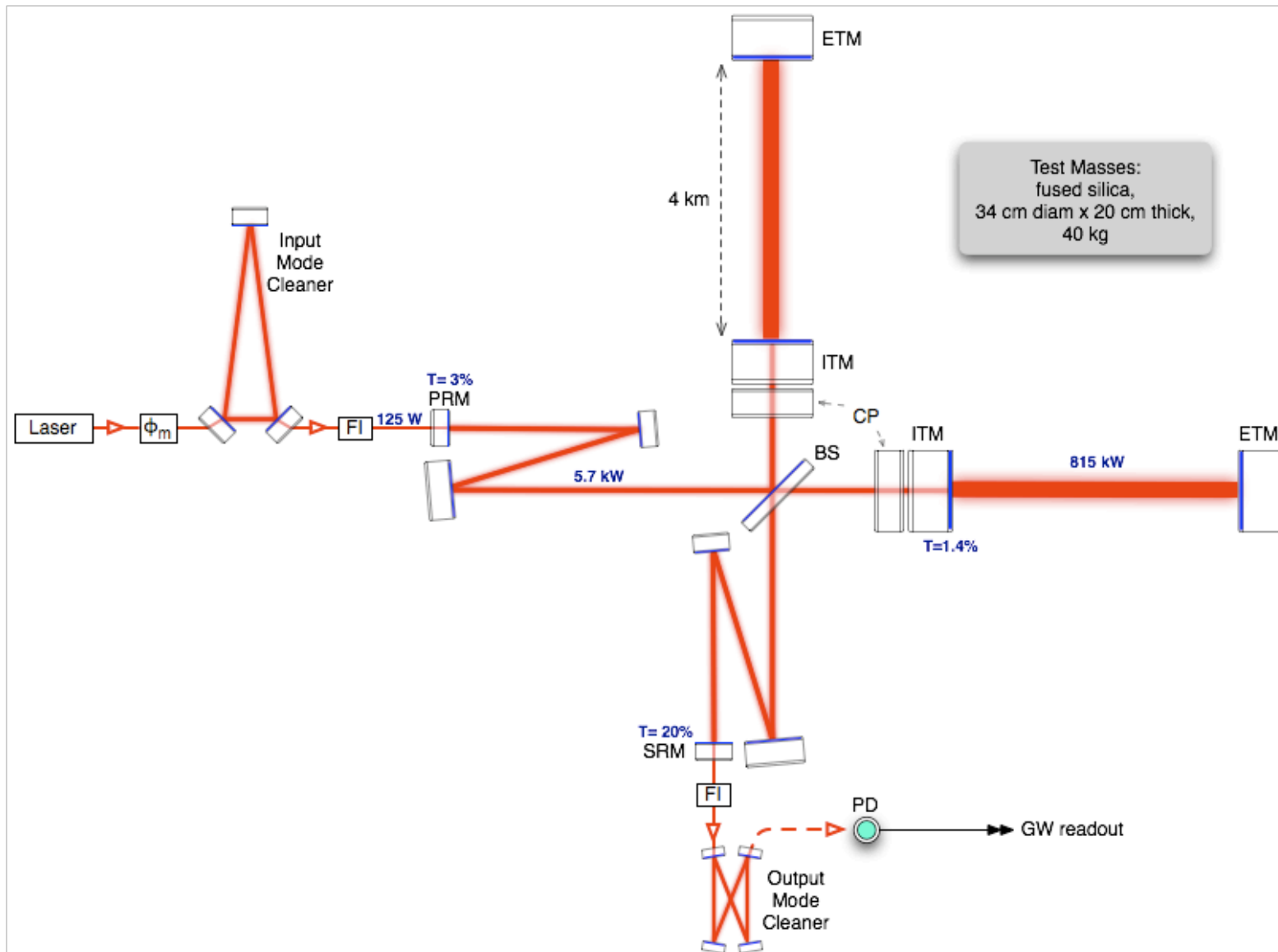
# **Advanced LIGO Technical Description Part I**

**NSF Review of Advanced LIGO Project  
25-27 April 2011**

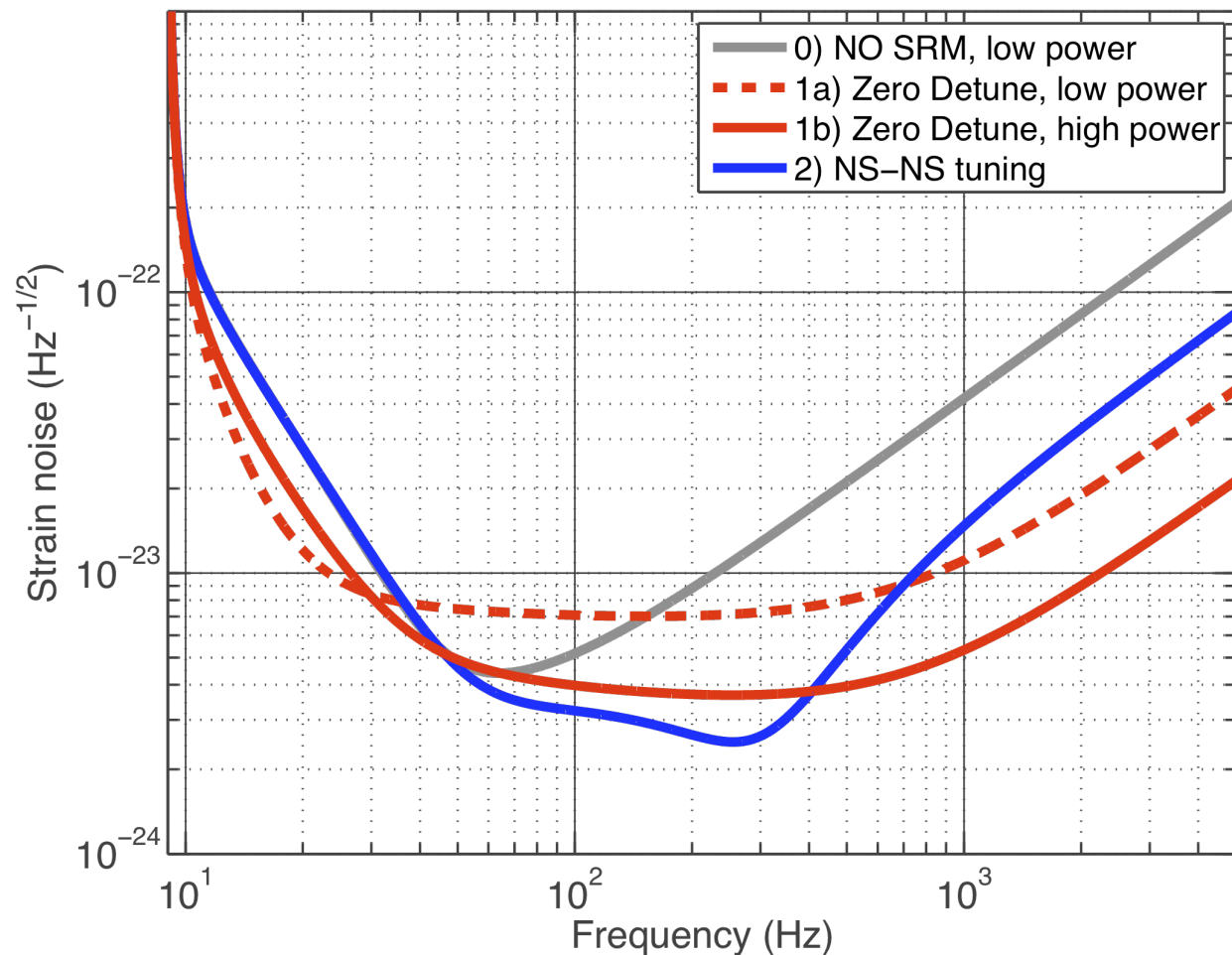
**Dennis Coyne, Caltech  
Peter Fritschel, MIT**

- **Systems Engineering (SYS) I: Interferometer design**
- **Pre-stabilized Laser (PSL)**
- **Input Optics (IO)**
- **Core Optics Components (COC)**
- **Interferometer Sensing & Control (ISC)**
- **Systems Engineering (SYS) II: High Power & gas damping**
- **Auxiliary Optics Subsystem (AOS)**
- **Seismic Isolation (SEI)**
- **Suspensions (SUS)**
- **Data Acquisition, Diagnostics, Networking & Supervisory Control (DAQ)**
- **Data Computing System (DCS)**
- **Facility Modifications & Preparation (FMP)**
- **Systems Engineering (SYS) III: layout, interfaces, etc**
- **Summary**

## Systems: Interferometer Design



## Interferometer Performance



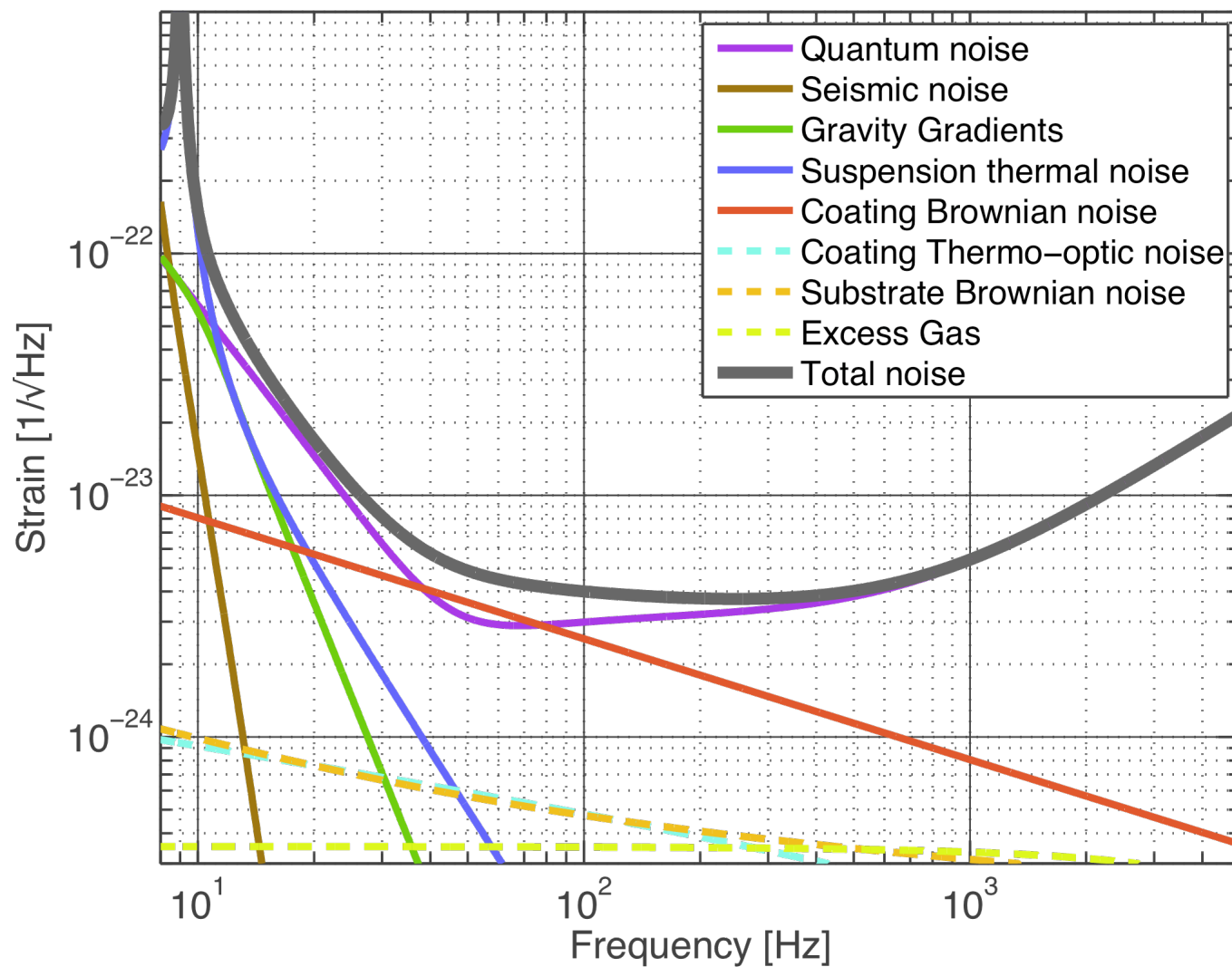
### Detection range for binary inspirals

case	NS-NS	BH-BH (30 $M_{\odot}$ )
0	150 Mpc	1.60 Gpc
1a	145 Mpc	1.65 Gpc
1b	190 Mpc	1.85 Gpc
2	200 Mpc	1.65 Gpc



## Limiting Noise Sources

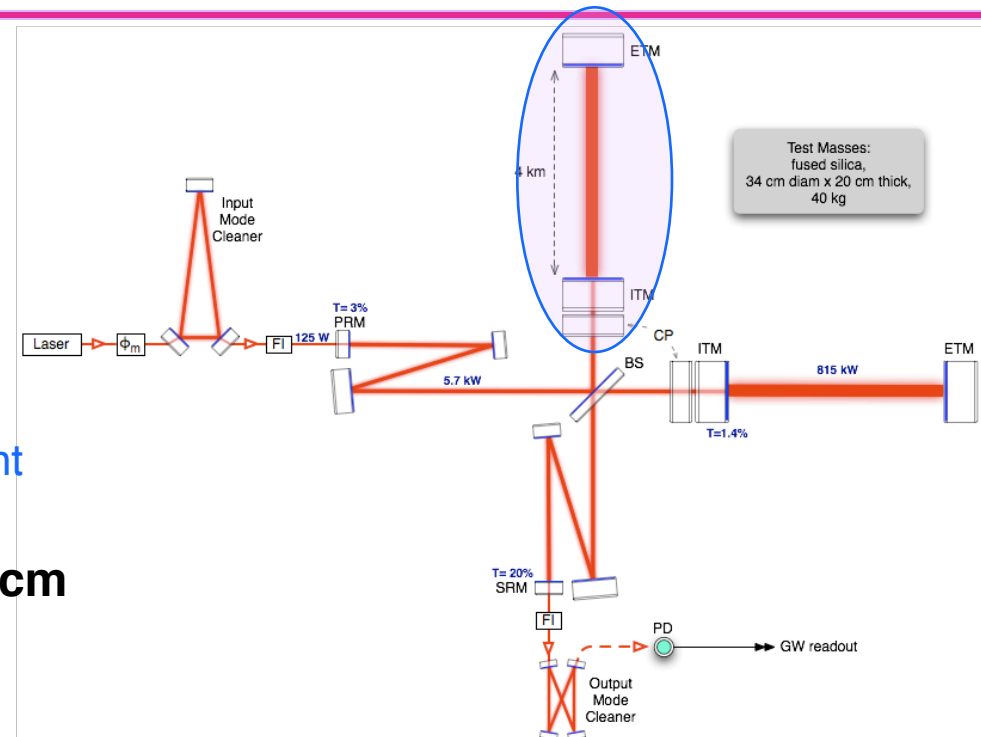
*Broadband tuning, full input power (125 W)*



## Key Interferometer Features

### Arm cavity design

- **Finesse: 450**
  - » 2x higher than iLIGO
  - » Value involves trade-offs between optical loss, sensitivity to noise in other degrees-of-freedom, and interferometer sensitivity in different modes of operation
- **Beam sizes: 6.2 cm on ETM, 5.3 cm on ITM**
  - » Approx. 50% larger than iLIGO, to reduce thermal noise
  - » Smaller beam on the ITM to allow smaller optic apertures in the vertex
- **Cavities are made to be dichroic**
  - » Low finesse cavity for 532 nm to aid in lock acquisition



- **Near-confocal design**

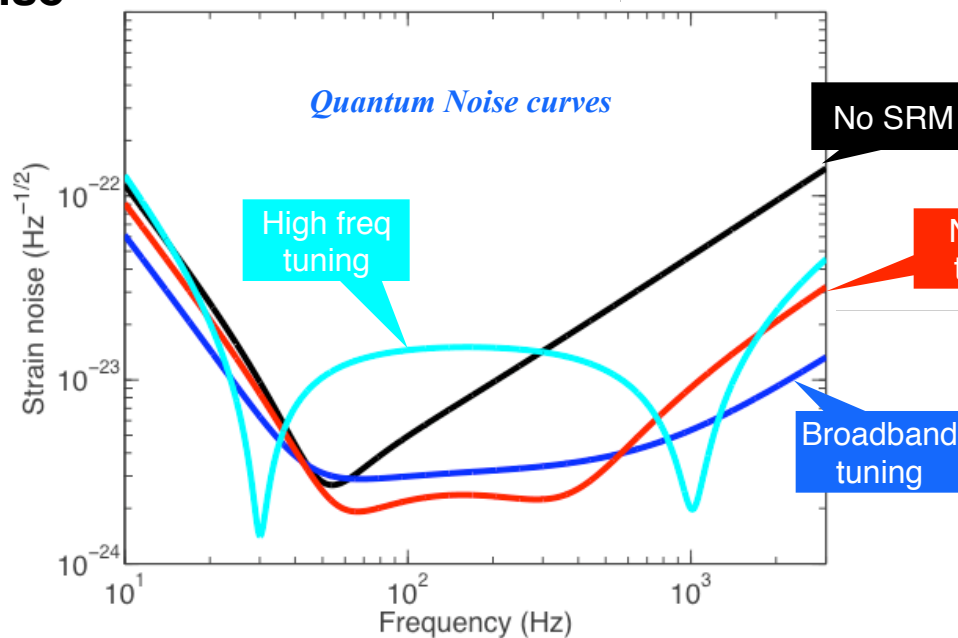
$$R_{ITM}, R_{ETM} \approx L$$

- » Gives better angular stability than the near flat-flat case

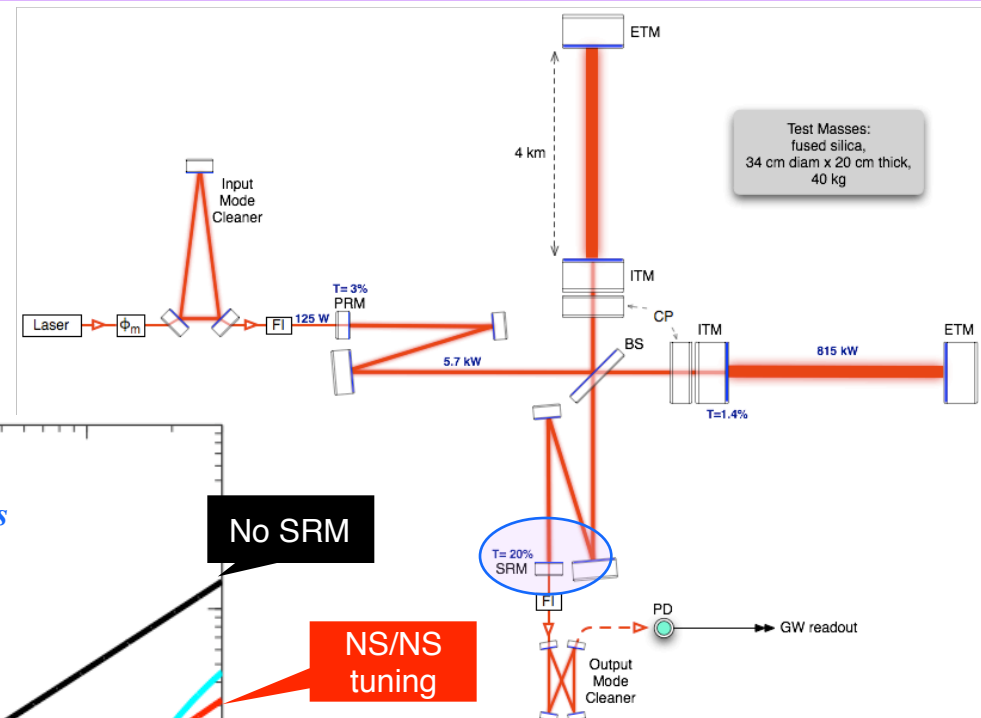
## Key Interferometer Features

### Signal Recycling

- Add a partially transmitting mirror to the anti-symmetric port
- Provides some ability to alter the interferometer frequency response

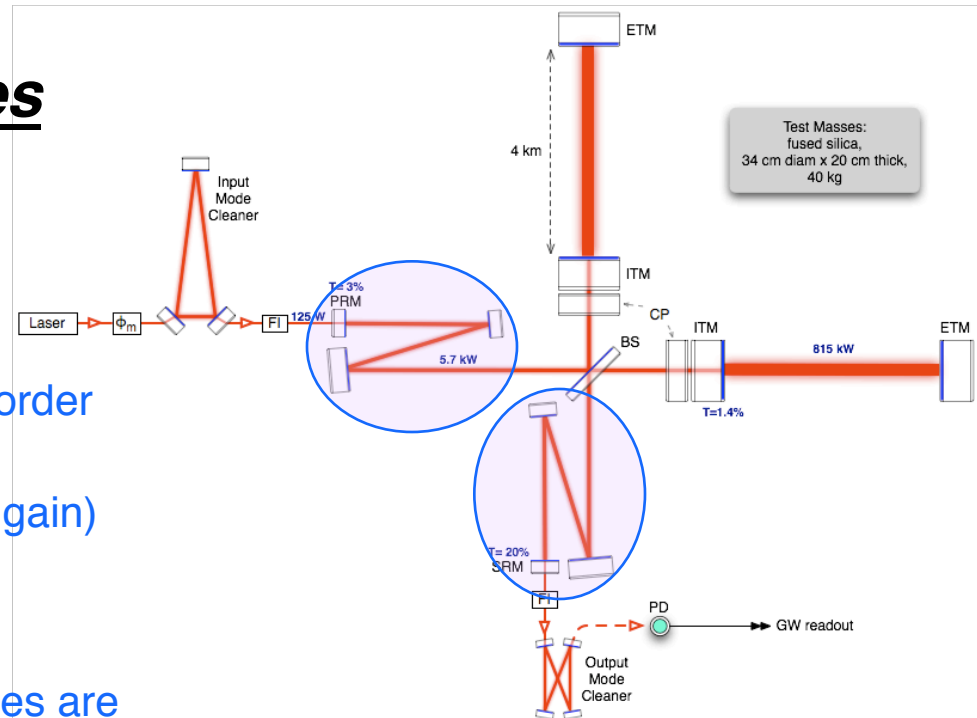


*Baseline is broadband tuning*



## Stable Recycling Cavities

- **iLIGO has a marginally stable recycling cavity**
  - » Nearly a plane-plane cavity; higher order spatial modes are nearly resonant
  - » Spatial mode quality (& thus optical gain) suffers
- **Stable geometry for AdvLIGO**
  - » Beam expansion/reduction telescopes are included in the recycling cavities
  - » Higher order spatial modes are suppressed
  - » Configuration is more tolerant to optical distortions



## Pre-stabilized laser (PSL)

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- High power laser: 180 Watts
- Laser frequency pre-stabilization & frequency actuation
- Pre-mode cleaner for spatial clean-up and high-frequency filtering
- Diagnostic tools
- Laser power stabilization
- Laser safety measures
- Facility infrastructure
  - » Laser and laser diode enclosures
  - » Instrument racks, crates, power supplies
  - » Supervisory controls & DAQ interfacing

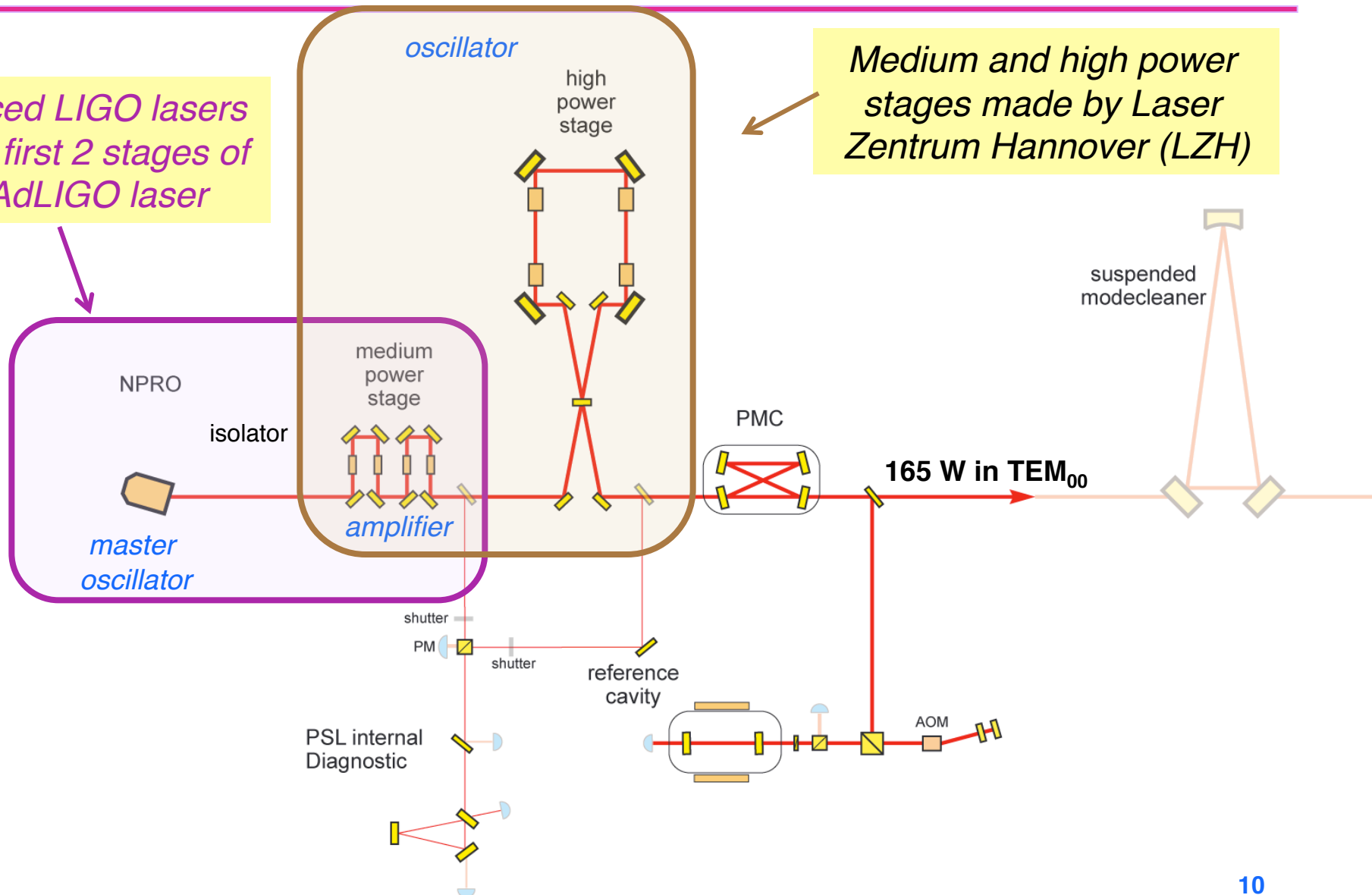
*Supplied by Albert  
Einstein Institute  
(Hannover)*

*Supplied by LIGO  
Lab*

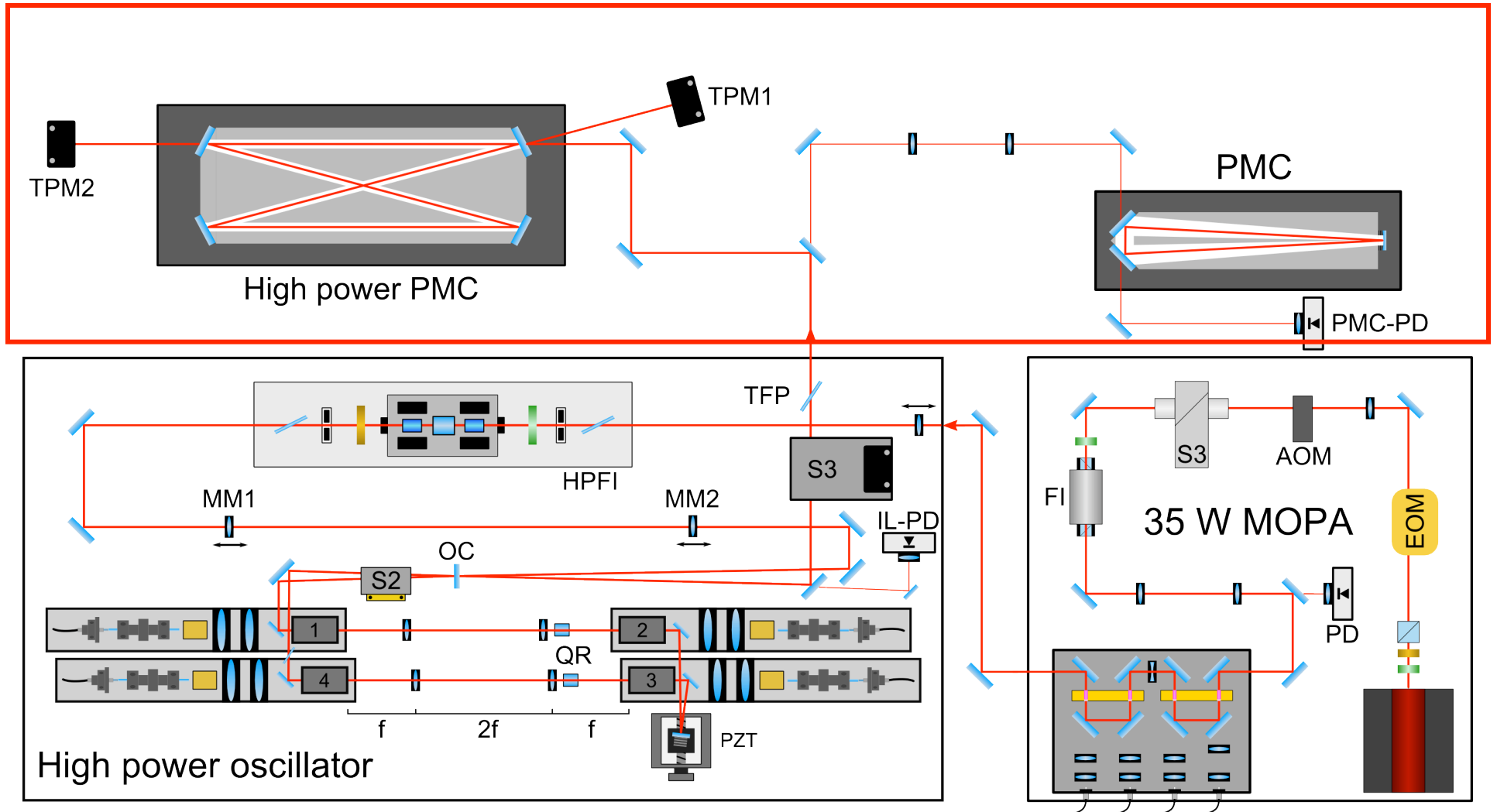
## Pre-stabilized laser

*Enhanced LIGO lasers are the first 2 stages of the AdLIGO laser*

*Medium and high power stages made by Laser Zentrum Hannover (LZH)*



## Pre-stabilized Laser

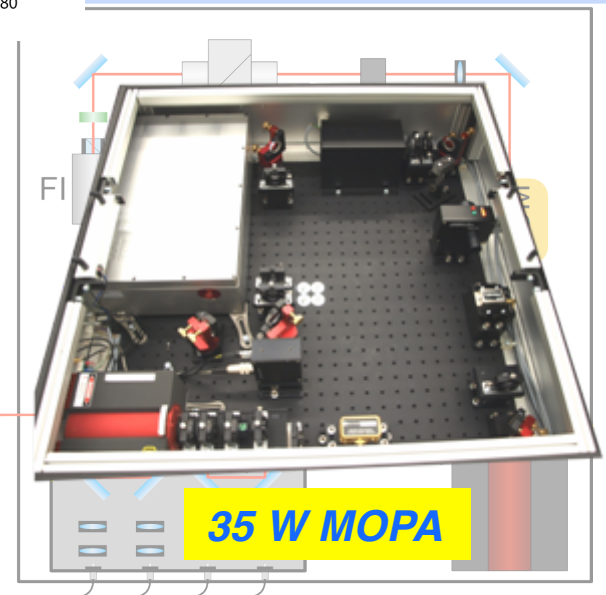
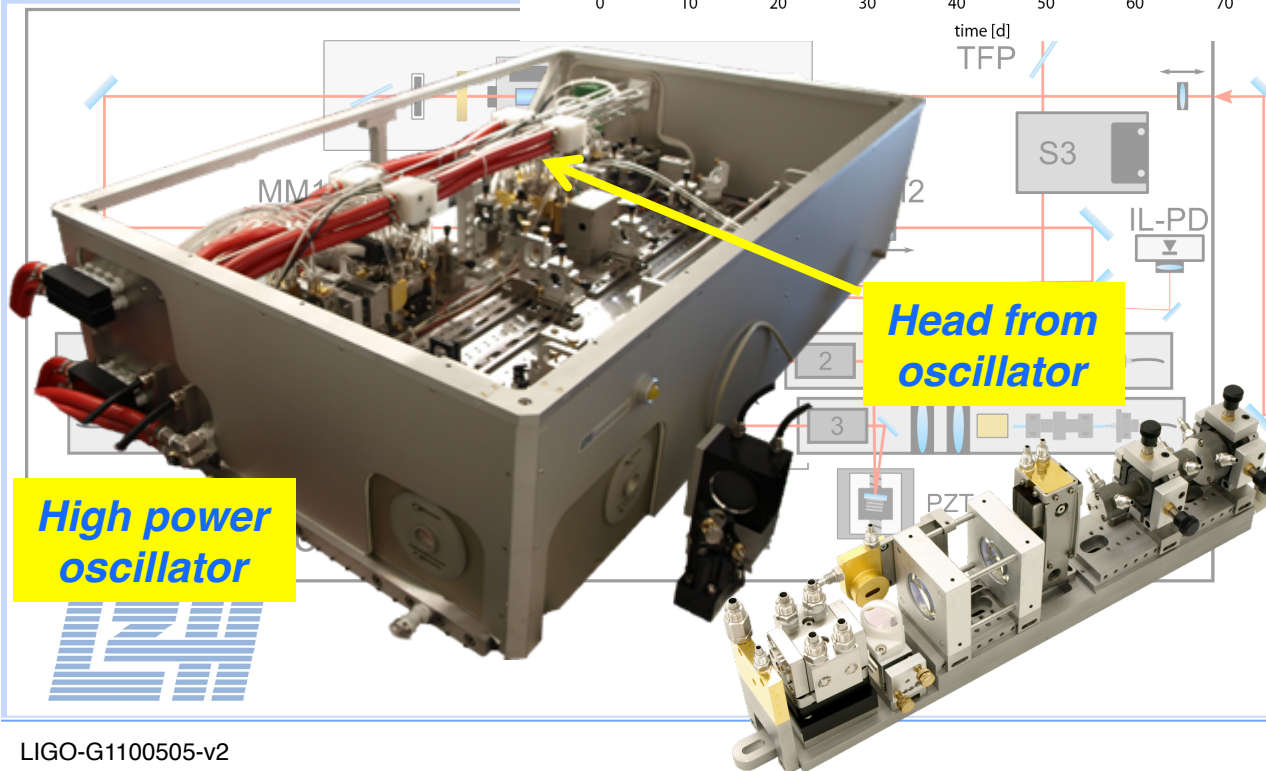
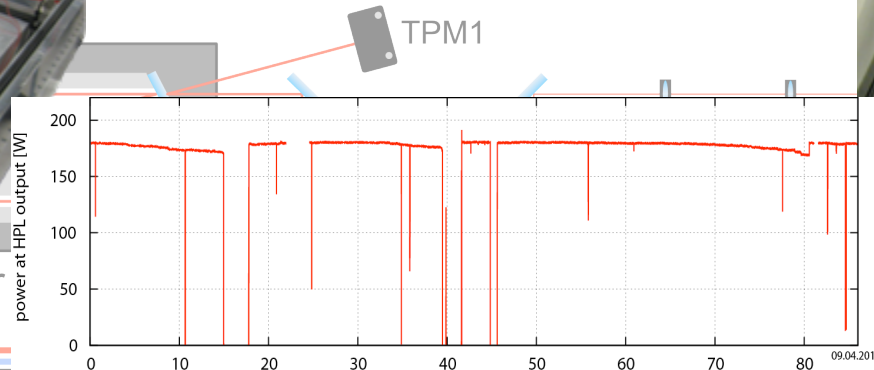
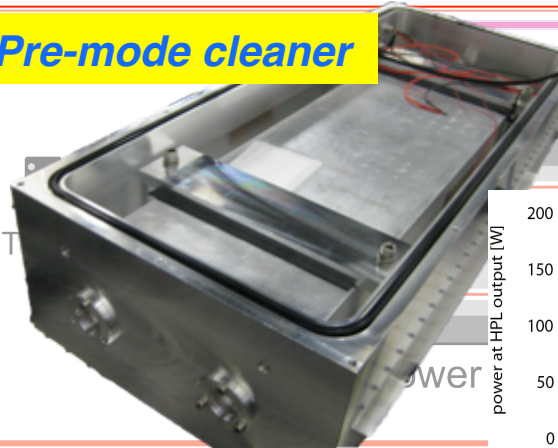




## Pre-Stabilized Laser

*Pre-mode cleaner*

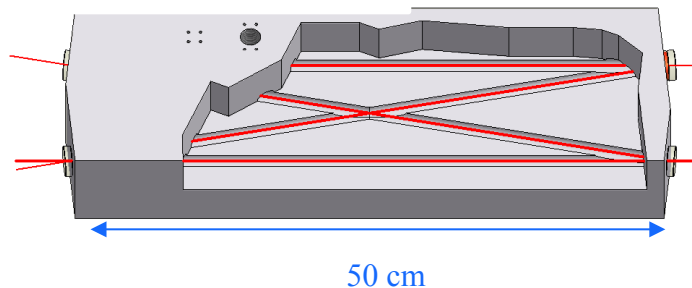
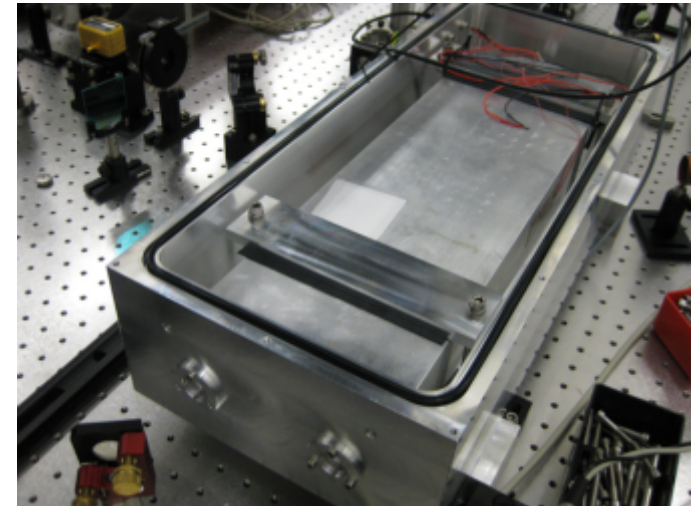
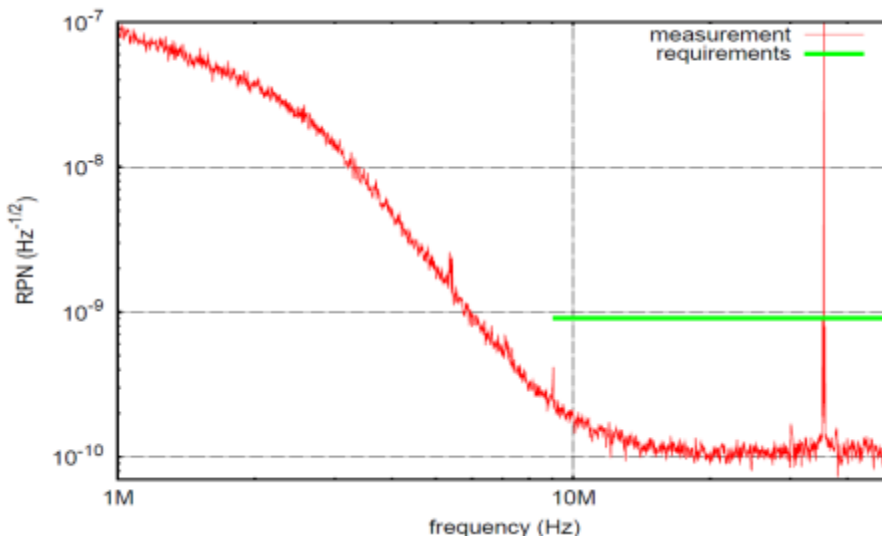
*Diagnostic breadboard*





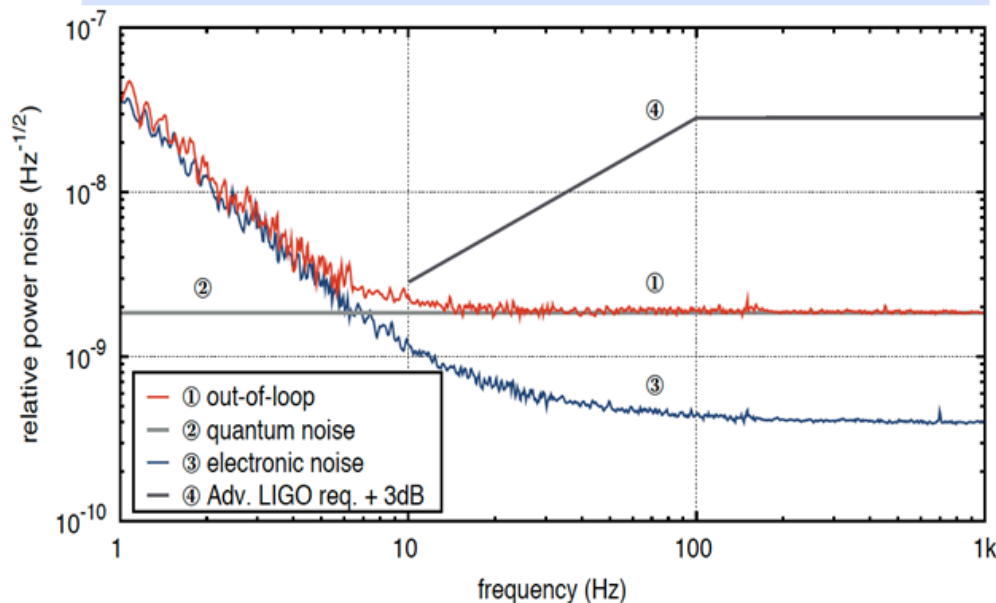
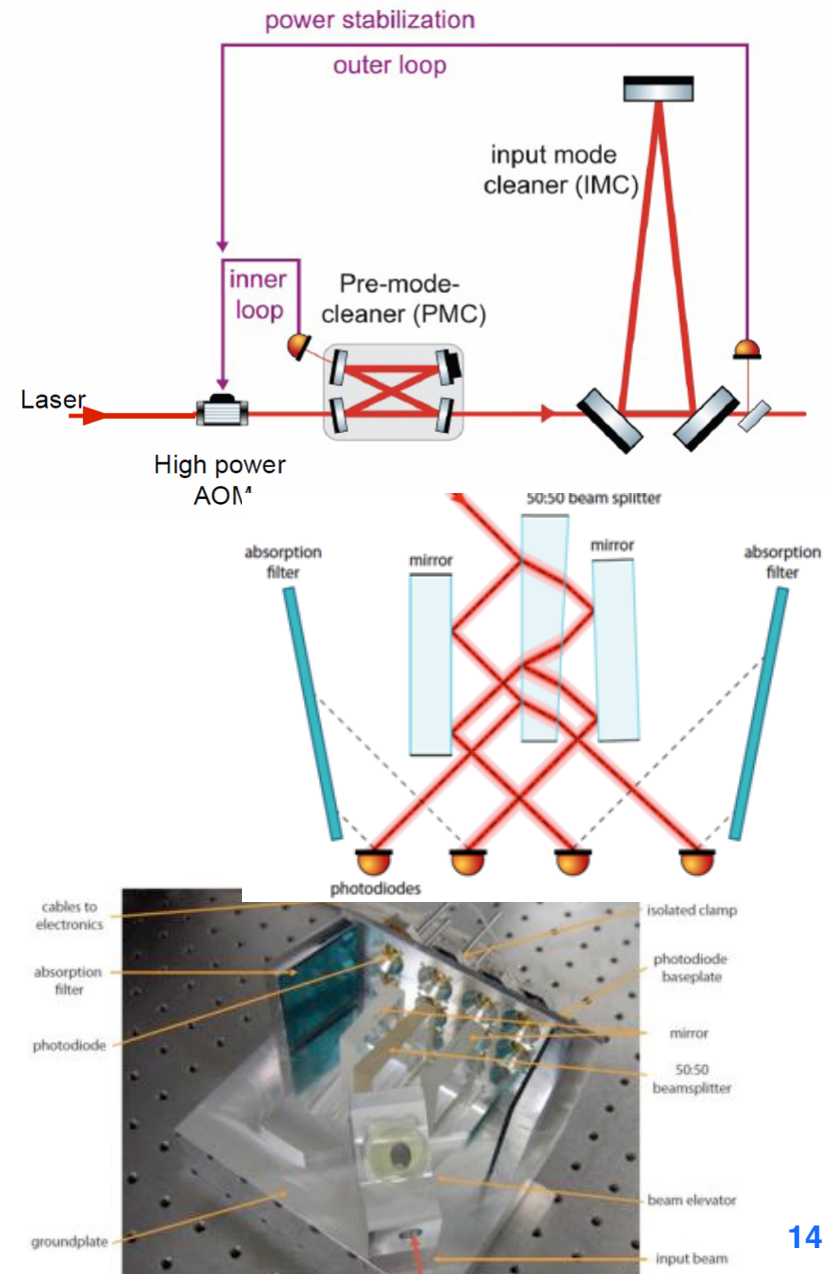
## Pre-mode cleaner: spatial & temporal filtering

- bow tie configuration, round-trip length of 2m
- Finesse of 124, circulating power 9kW (200W input)
- Linewidth 575 kHz (HWHM)
- Length control with automatic lock acquisition
- PZT actuator / thermal actuator to off-load PZT



# Laser Power Stabilization

- High power acousto-optic modulator provides actuation
- Prototype power stabilization photodetector (outer loop)
- Stabilized noise requirement of  $RIN < 2 \times 10^{-9} / \text{Hz}^{1/2}$  at 10 Hz: demonstrated w/ NPRO laser





## LLO PSL currently being installed



Laser Area Enclosure:  
HEPA filtered airflow &  
acoustic shielding



Pump Laser  
Diodes in  
remote room



Laser Stabilization  
Electronics

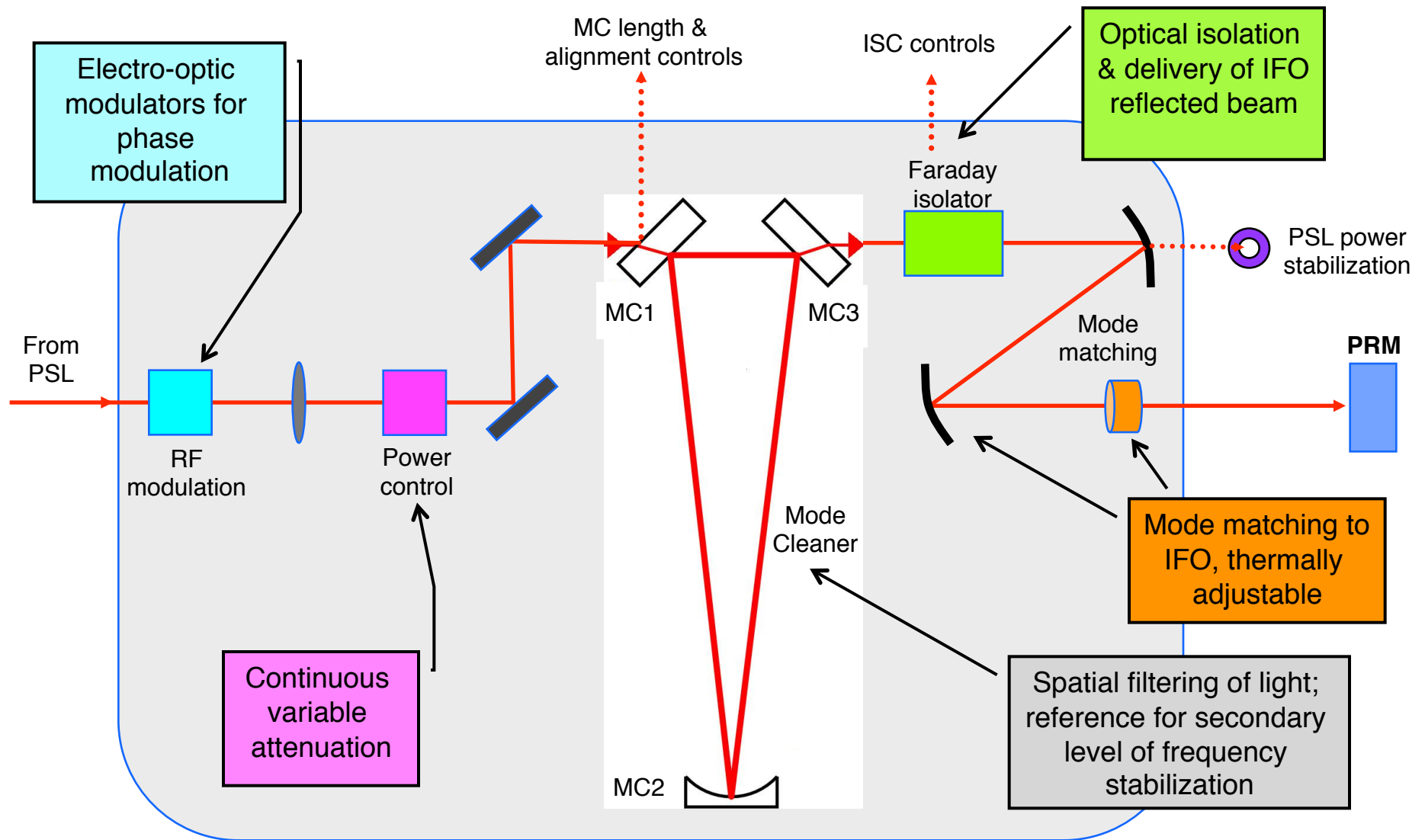


## PSL Status

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- **First laser arrived in January 2011 & is being installed**
  - H2 laser to ship in June 2011
- **Fabrication continues at LZH**
  - » All 35 W MOPA's have been fabricated
  - » 2<sup>nd</sup> and 3<sup>rd</sup> High Power Lasers have been assembled
- **A full PSL 'Reference Laser' remains in operation at AEI**
  - » Long term testing
  - » Control loop tuning and other testing
- **Final design review of outer-loop photodetector in near term**
- **No significant technical issues remaining**

# Input Optics

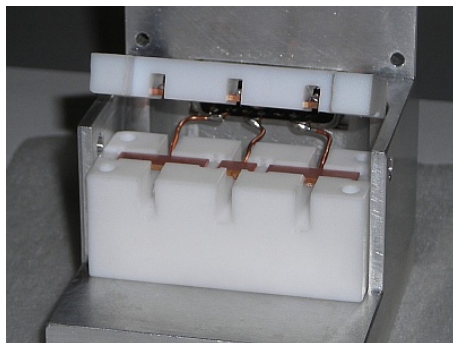




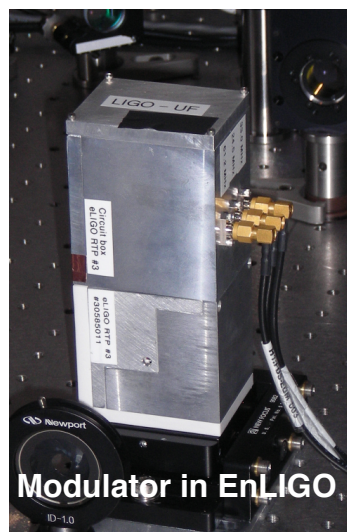
## IO: Modulators and Isolators

- **Phase modulator is rubidium titanyl phosphate (RTP)**

- » Electro-optic response similar to  $\text{LiNbO}_3$
- » lower absorption  $\rightarrow$  lower thermal lensing
- » Large aperture: 4 mm x 4 mm
- » Multiple electrodes on single crystal for multi-RF drive

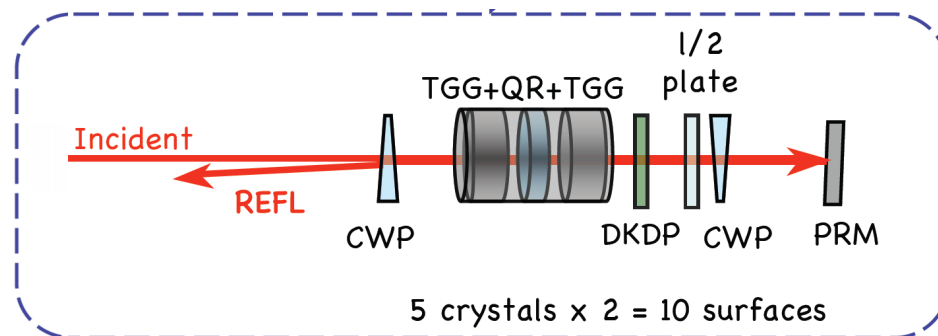


- » Tested to 140 W

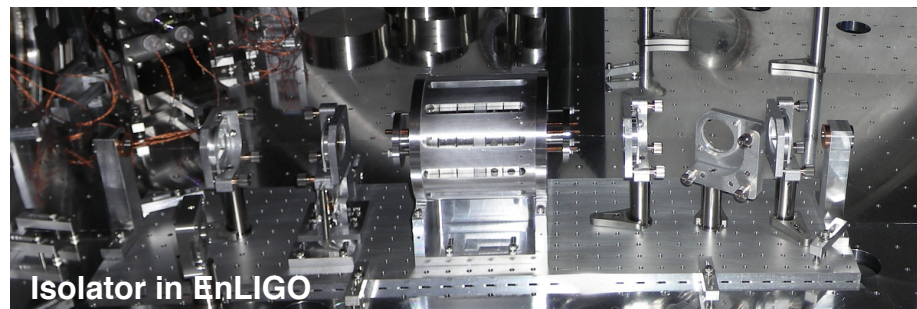


- **In-vacuum Faraday Isolator**

- » Thermal birefringence compensation using two crystals and a quartz rotator

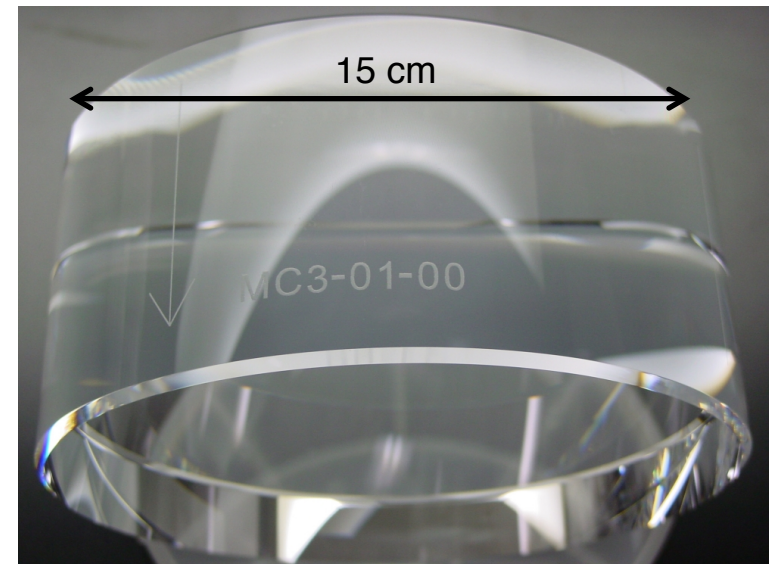
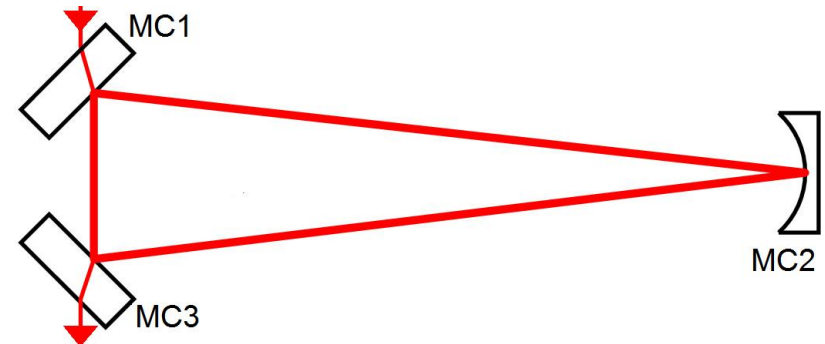


- »  $-dn/dT$  element (DKDP) to compensate thermal lensing

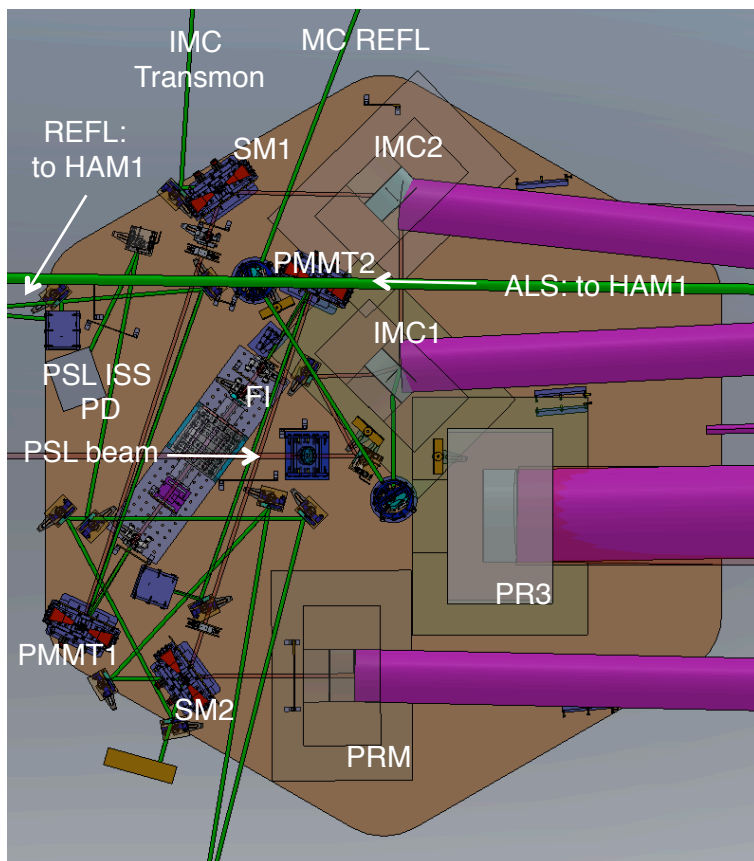


## Input Mode Cleaner Design

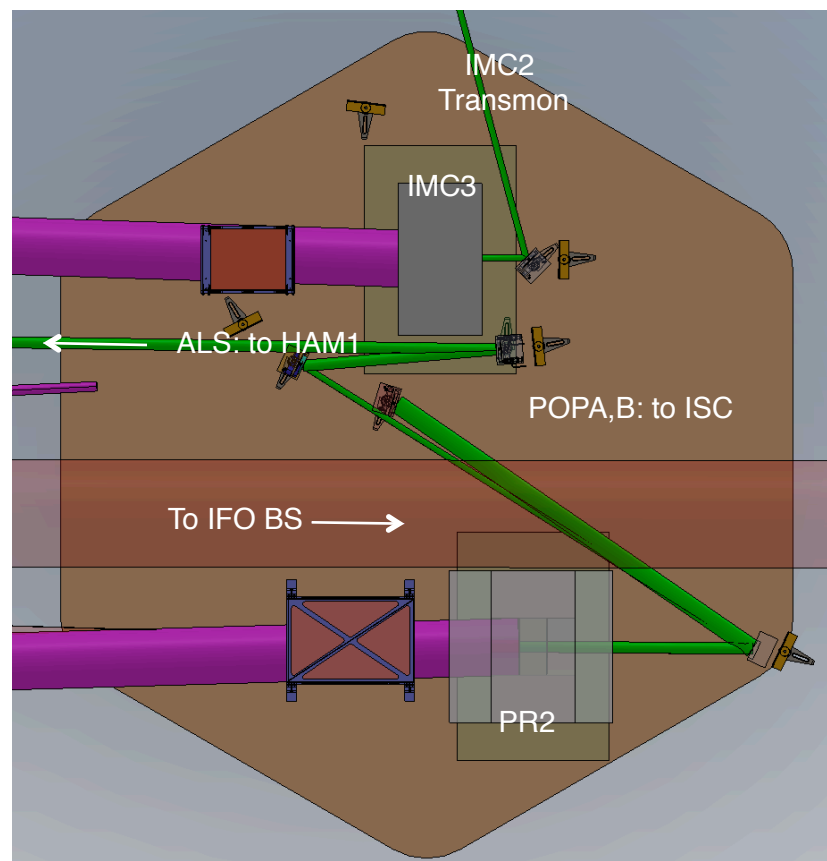
- **Triangular ring cavity**
- $L/2 = 16.5$  m
- **FSR = 9.1 MHz**
- **Finesse = 520**
- $P_{\text{stored}} = 23$  kW (@ 165 W input)
- **MC mirrors suspended from triple suspensions**
- **MC mirrors**
  - » 15 cm diameter x 10 cm thick
  - » 3 kg: 12x heavier than iLIGO, to limit noise due to radiation pressure



## HAM2



## HAM3



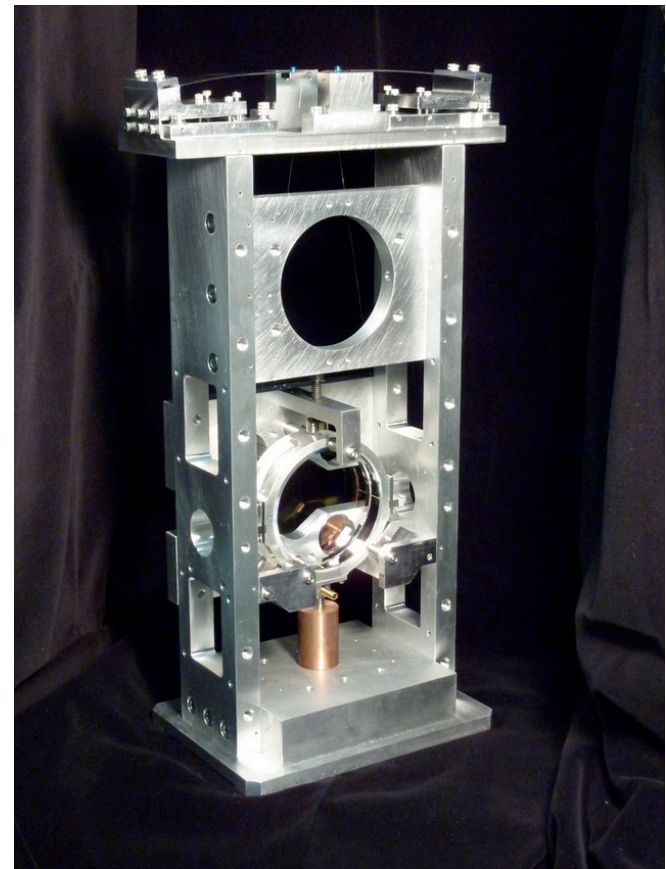


## Ham Auxiliary Suspensions

- **Steer the beam between the IMC output and the Power Recycling Mirror (interferometer input)**
- **Final design review completed in fall 2010**

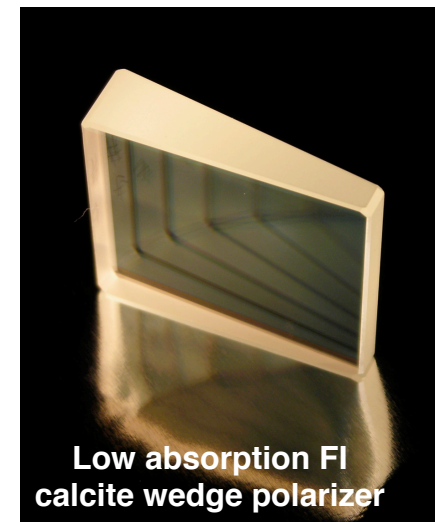
Single stage suspension,  
including blade springs for  
vertical compliance

Suspension provides isolation to  
maintain low beam pointing  
fluctuations, & active control of  
beam pointing



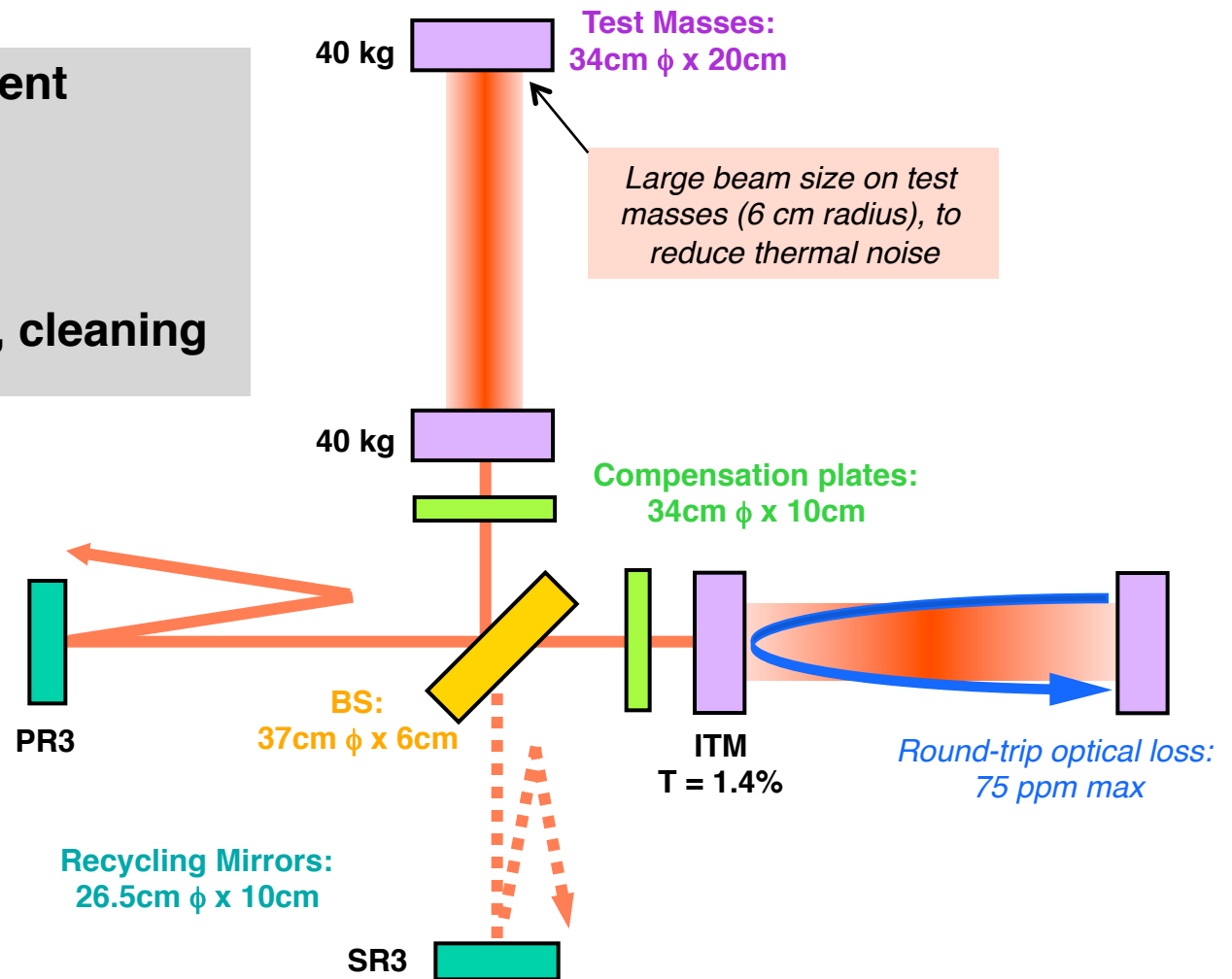
## Input Optics Status

- **Final design elements completed in past ~6 months**
  - » HAM Auxiliary Suspensions & IO section baffles
- **Production status**
  - » All Input Mode Cleaner mirrors and small recycling cavity mirrors (PRM, SRM, PR2, SR2) have been polished and coated
  - » In-house Metrology in progress: IMC mirrors show suitably low absorption, 0.4-0.5 ppm
  - » HAM Aux suspension components all fabricated
  - » Modulator crystals and custom polarizers received
- **No significant technical issues remaining**



## Core Optics Components

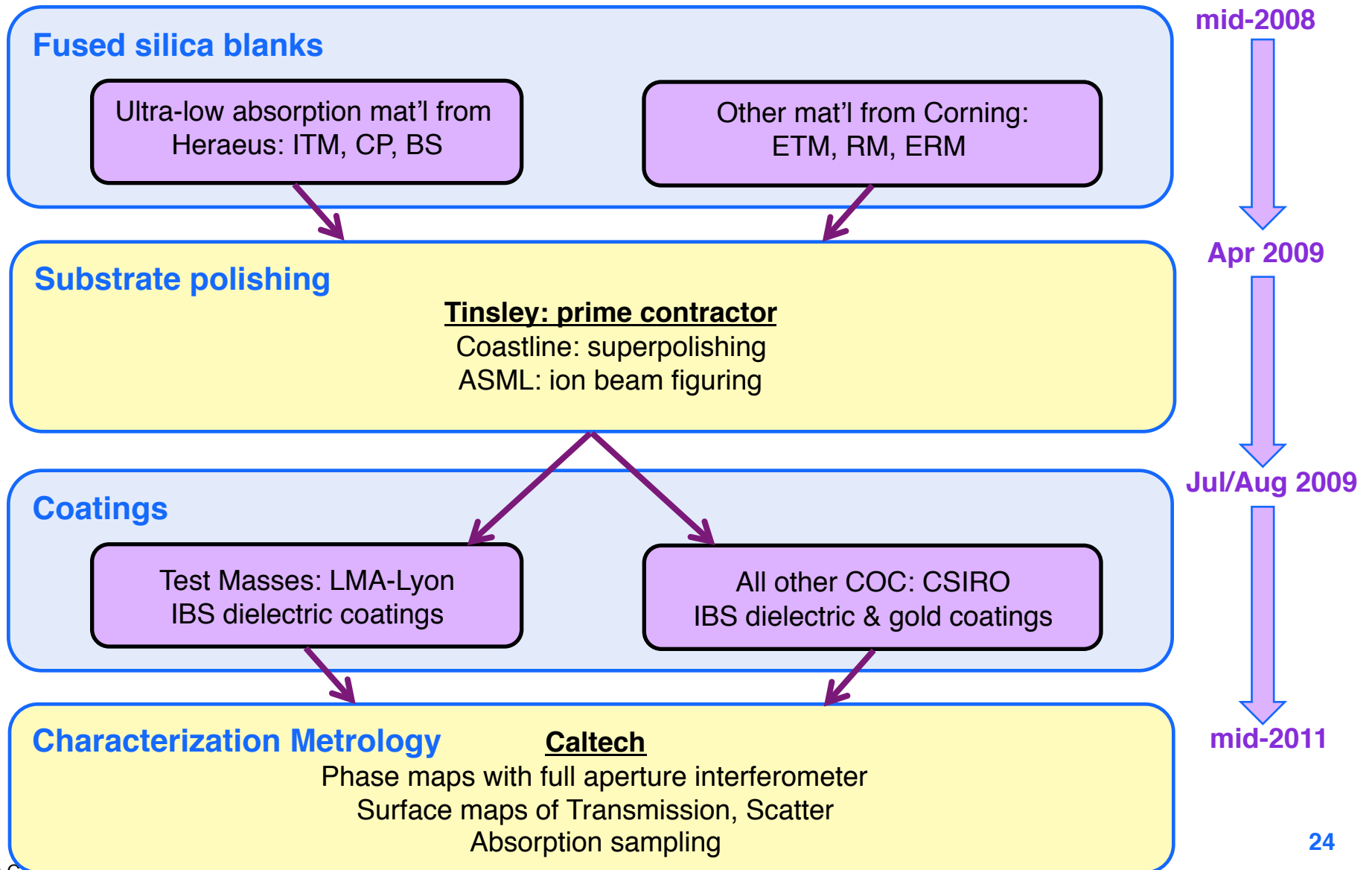
- Substrate procurement
- Substrate polishing
- Dielectric coatings
- Metrology
- Transport, handling, cleaning



All COC are fused silica substrates with ion-beam sputtered dielectric coatings



## Core Optic production flow



## COC Polishing

- **Arm cavity loss goal: 75 ppm round-trip (2x lower than iLIGO)**
  - » Requires low micro-roughness, low mid-spatial frequency distortion, good ROC matching between optics

### **Test mass specifications:**

- < 0.3 nm rms figure (tilt, astig., power removed)
- Matching of ROCs to  $\pm 3$  m (out of 2000 m)
- < 0.16 nm rms micro-roughness

### **Technique:**

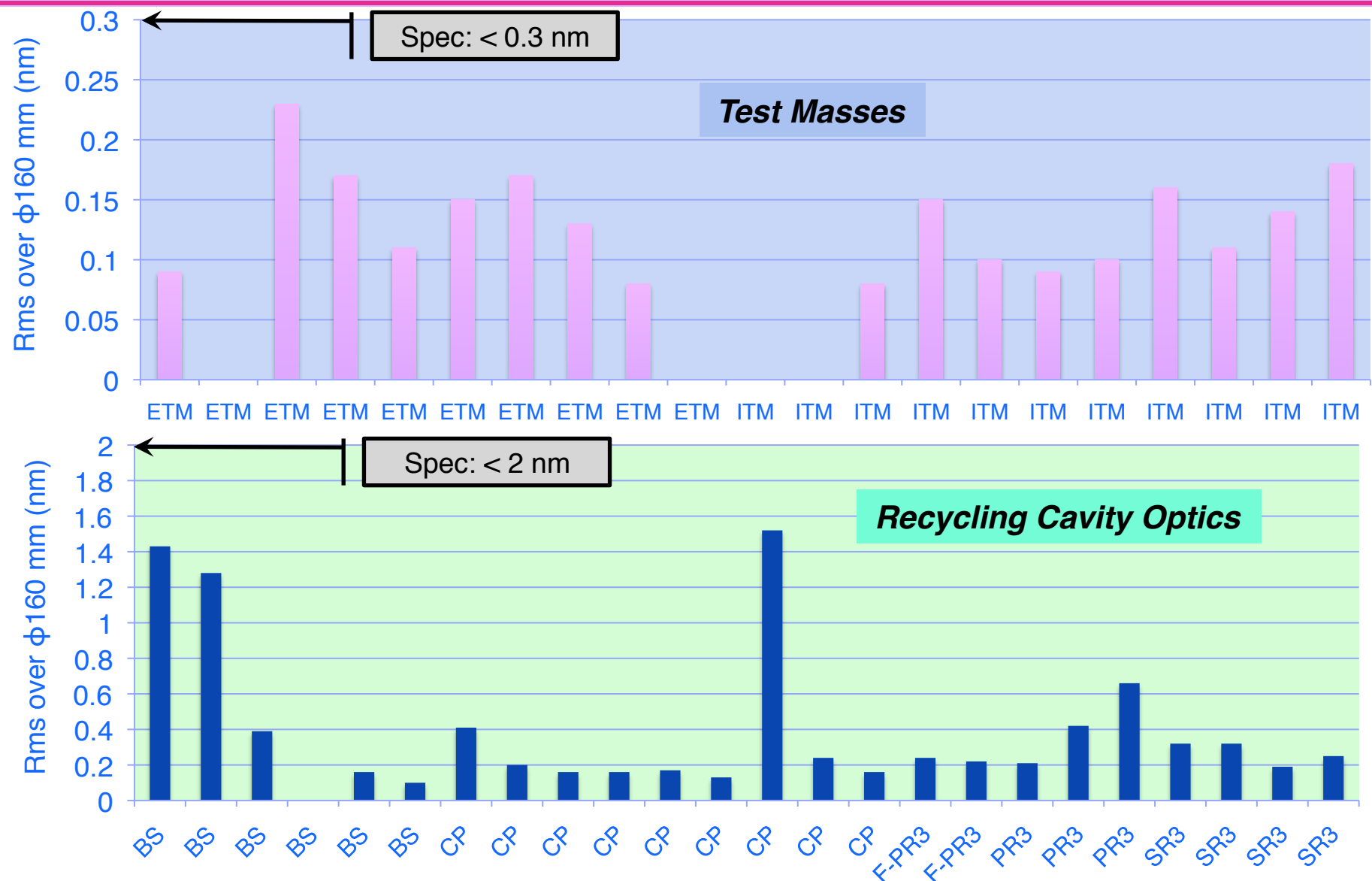
- Initial figuring and superpolishing done at Coastline Optics
- Final ion beam figuring at ASML

## *Polishing Results:*

- **12 of 20 polished Test Masses received – factoring in some to be redone**
  - » Radius of curvature is being met to  **$\pm 0.6$  m** on average (vs 3 m spec)
  - » Micro-roughness is **0.12 nm rms** on average (vs 0.16 nm spec)



## Polishing: wavefront error (power & astigmatism removed)





## COC Coatings: Test Masses

- **Baseline Requirements for Test Mass coatings**

- » Low scatter: < 2 ppm
- » Low absorption: < 0.5 ppm
- » Low mechanical loss
  - Several years of LSC R&D resulted in a better coating formula
  - Alternating layers of silica and titanium-doped tantala (25%); gives approx. 40% lower loss than non-doped tantala (20% reduction in thermal noise amplitude)
- » Low wavefront distortion
  - Radius-of-curvature change: < 8 nm sag over central area
  - Higher order Zernikes: < 0.5 nm rms

} *Rely on IBS coating technology from qualified vendors*

- **LMA coating designs for the test masses are completed**

- » Non- $\frac{1}{4}$ -wave stack: accommodates arm locking w// green beam & reduces thermal noise

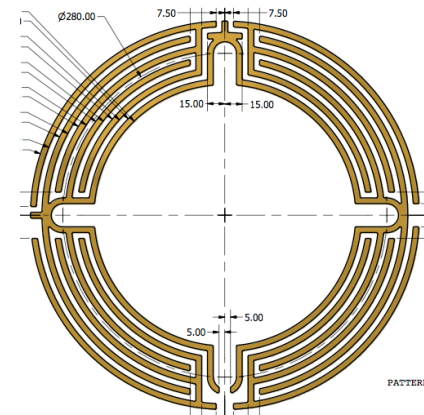
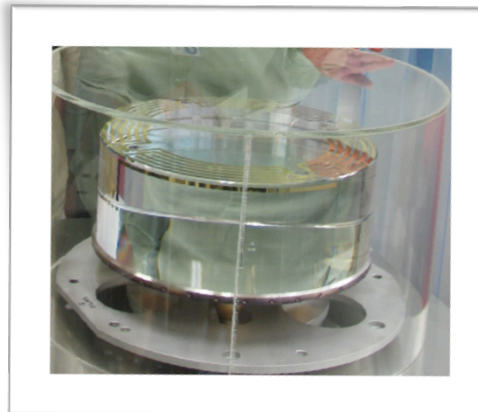
	ETM	ITM
1064 nm	T = 5 ppm	T = 1.4 %
532 nm	T = 5%	T = 1%
Thermal noise w.r.t. $\frac{1}{4}$ -wave design	-2.5%	-5%

- » Absorption has been proven on first TM coating: **0.3-0.35 ppm**
- » Wavefront distortion spec not yet met – factor of  $\sim 2$  off; LMA is actively pursuing techniques to improve this

## COC coatings: Recycling Cavity optics

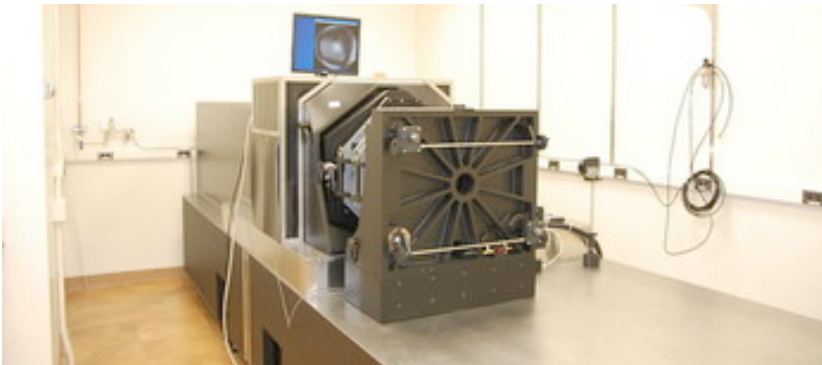
- **CSIRO coating designs for other optics nearly complete**
  - » Dielectric coatings also need to accommodate Hartmann sensor probe beams (near IR) & 532 nm beams
- **Tooling/fixtures complete**
  - » Sample coating runs made to prove fixturing
- **Anti-Reflection coatings in the Recycling Cavities: need low AR and low absorption**
  - » Much work to understand initial high absorption ( $\sim 10$  ppm); now understood and able to produce  $< 1$  ppm absorption
  - »  $AR < 50$  ppm req'd: indications are this will be achieved
- **Gold coatings on Reaction Masses for the Electro-Static Drive**

End Reaction Masses  
are completed &  
delivered





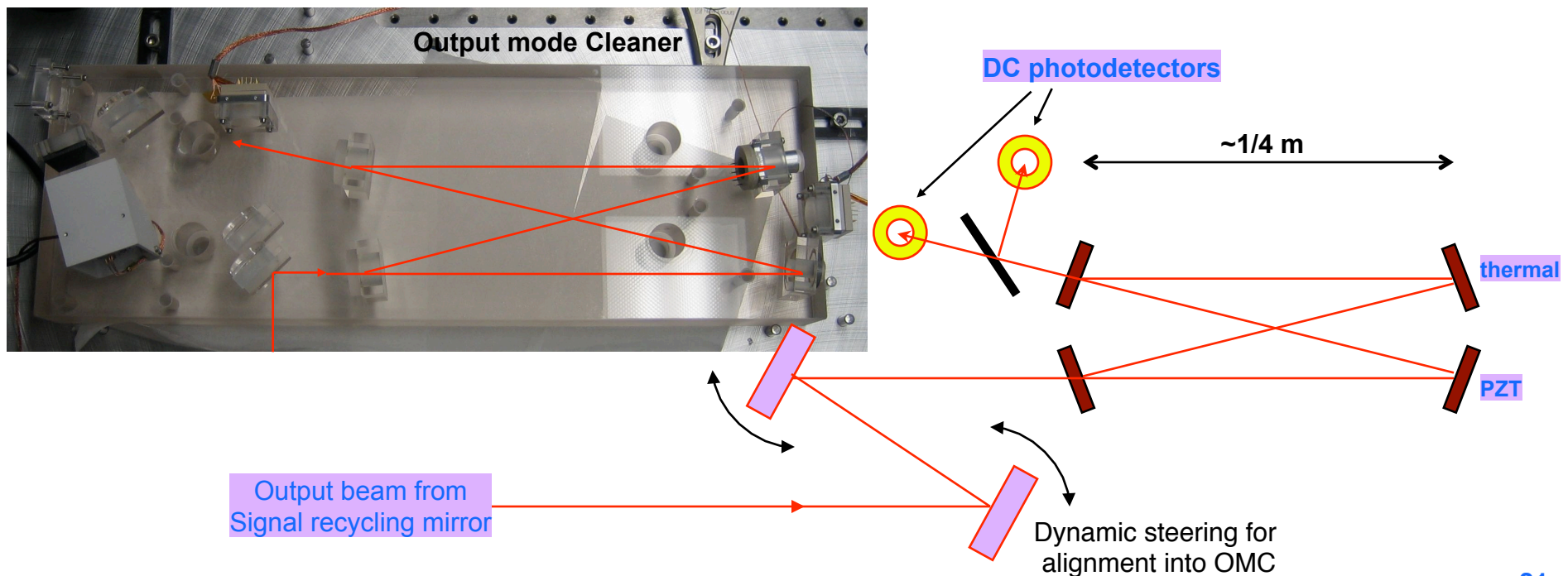
- **Polishing of initial set of mirror blanks nearly complete**
- **Replacement blanks being supplied for Fold Mirrors and some ETMs**
  - » Corning material found to change sagitta (warp) under annealing: first at CSIRO with FMs, than at LMA with ETMs
  - » Both types are being replaced with Heraeus material that is stable under annealing
- **Dielectric coatings**
  - » Several technical issues have been found and fixed at both CSIRO and LMA
  - » *Critical remaining issue is achieving wavefront smoothness on the Test Masses (LMA)*
  - » First Test Mass, for the H2 Y-arm ITM, recently delivered to LHO; suitable for first arm cavity test, will need to be replaced in the long term
- **Characterization Metrology**
  - » Zygo full aperture phase-shifting interferometer up and running at Caltech



- **Global sensing & control of the interferometer length degrees-of-freedom**
  - » LSC: Length Sensing & Control
  - » 4km arm lengths, recycling cavity lengths, Michelson, final stage of frequency control
  - » *Readout of the gravitational wave channel*
- **Global sensing & control of the interferometer alignment**
  - » ASC: Alignment Sensing & Control
  - » 4 test masses + 1 beamsplitter + 2 recycling mirrors = 7
- **Lock acquisition of the interferometer**
  - » Arm Length Stabilization system
- **Detection tables for all senses beams**
  - » Opto-mechanical hardware; photodetectors
- **RF components: sources, distribution, demodulation**
- **Digital controls hardware and software for all length and alignment controls**

## ● DC (homodyne) detection

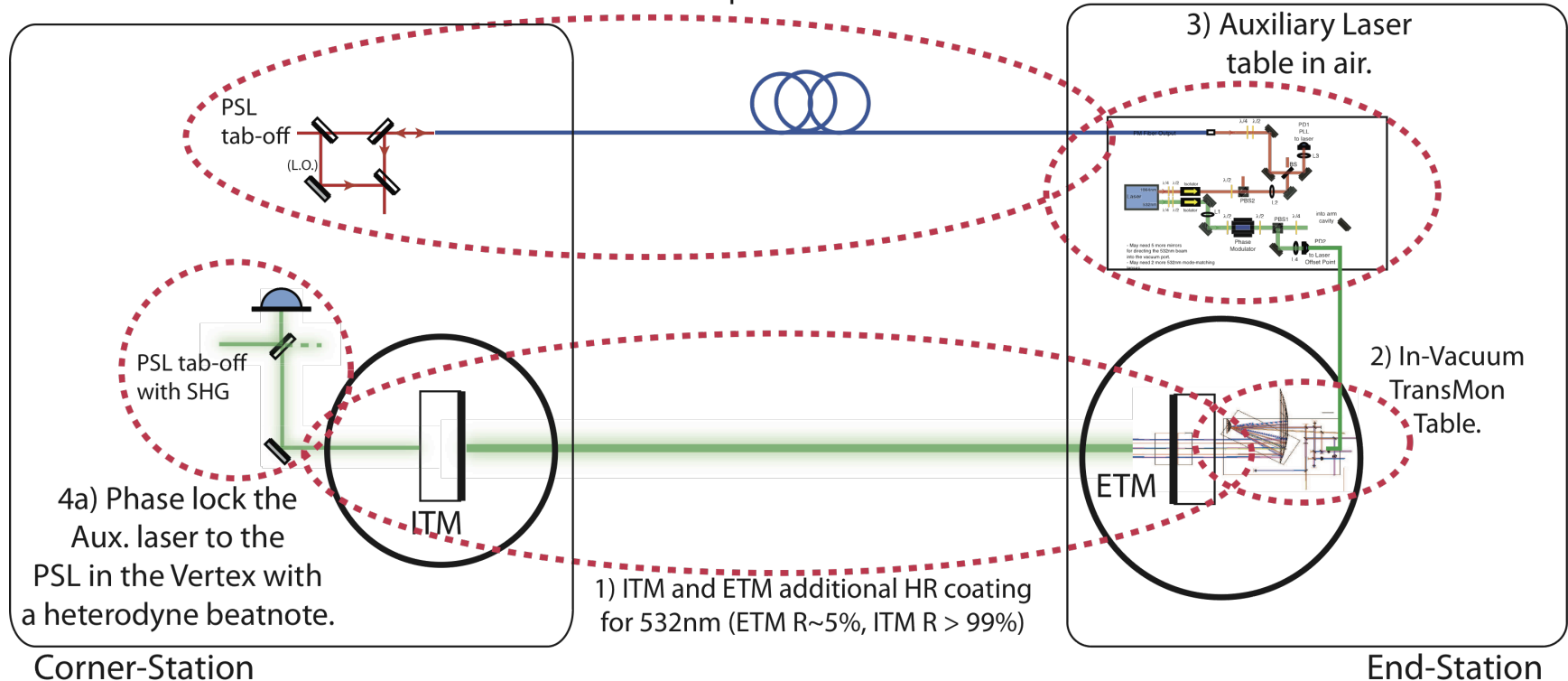
- » Offset the arm from the dark fringe, to get a signal linear in strain
- » Use an output filter cavity to reduce shot noise (OMC = Output Mode Cleaner)
- » Two OMCs made for and operated in Enhanced LIGO; these will be re-used for first 2 aLIGO interferometers
- » Next generation OMC will be made for 3<sup>rd</sup> interferometer, & eventual replacement of other 2



# ISC: Lock Acquisition & Arm Length Stabilization

4b) Delivery of the PSL phase reference to the End-Station via optical fiber.

*ALS being designed and delivered by ANU*



## ● Lock Acquisition: strategy developed with E2E time-domain simulation

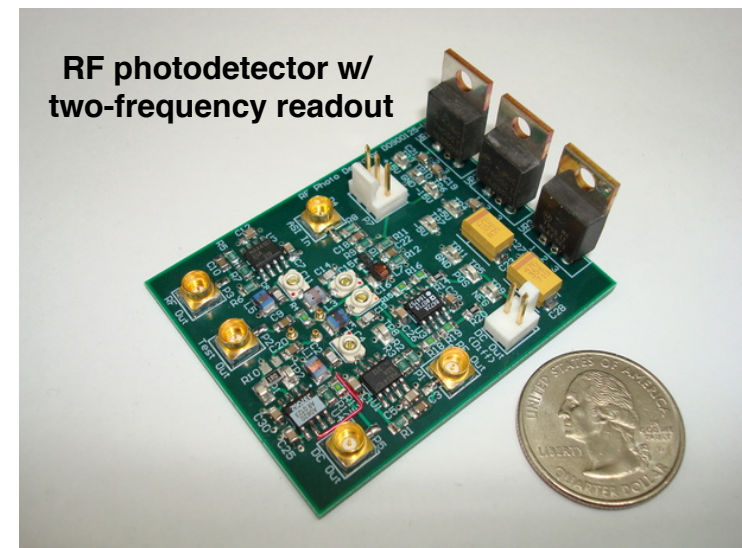
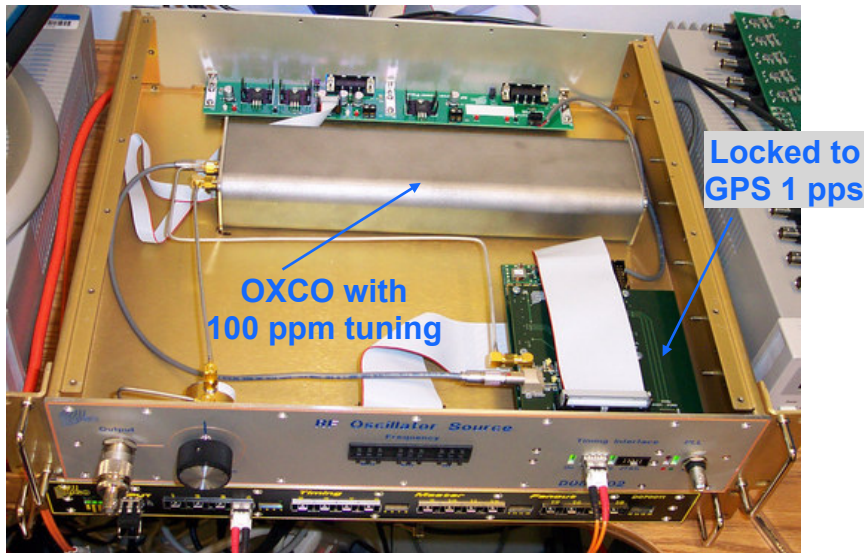
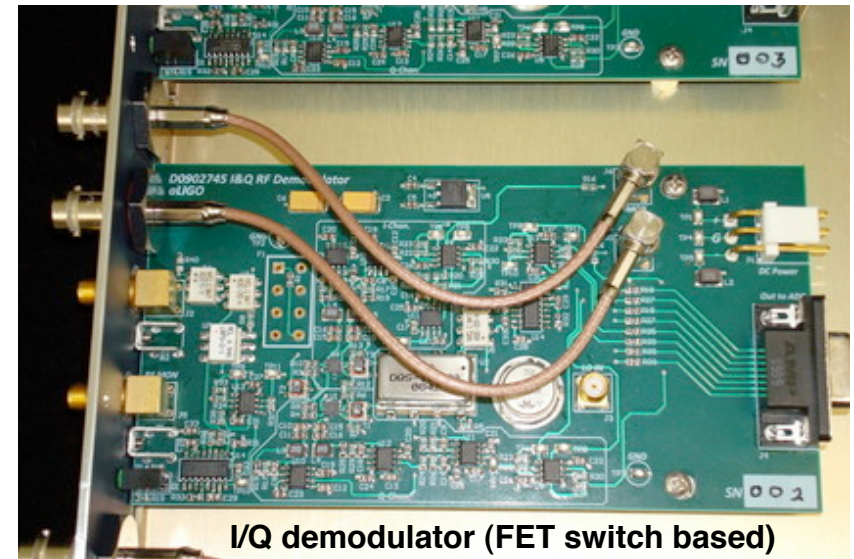
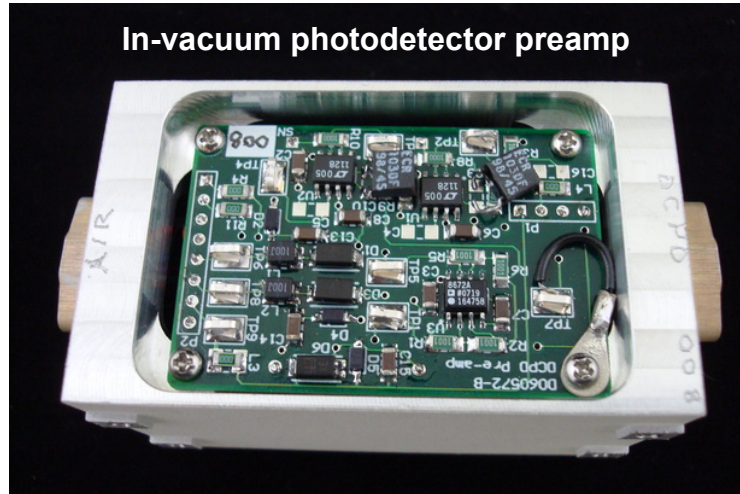
- » ALS stabilizes the arms to ~10 nm off-resonance, to ~ 1nm residual motion
- » Three DOF in the corner are controlled using RF signals
- » Arms are brought into resonance in a controlled fashion



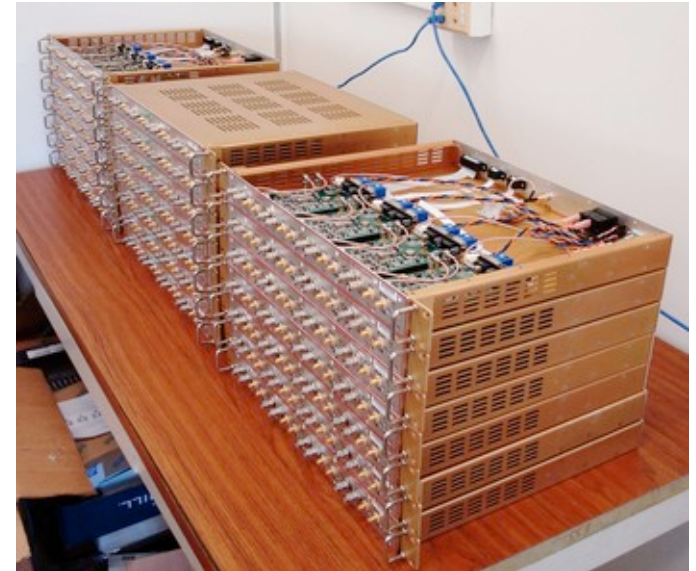


# ISC Electronics Development

*approximately 20 types of custom electronics modules*



- **Final design review completed in June 2010**
- **Electronics production underway**
  - » RF oscillators and distribution amplifiers complete
  - » RF I&Q demodulators complete
  - » Quadrant photodetector transimpedance amplifier
  - » Whitening / VGA chassis
- **Custom optics all ordered**
  - » 1" & 2" mirrors, splitters, lenses: super-polished, IBS coated
- **Opto-mechanical components largely procured**
  - » In-vacuum mirror mounts, piezo-actuators, etc.
- **Current focus is preparations for the first Arm Cavity**
  - » Arm Length Stabilization: optics table at End Station
  - » Transmission Monitor optical breadboard





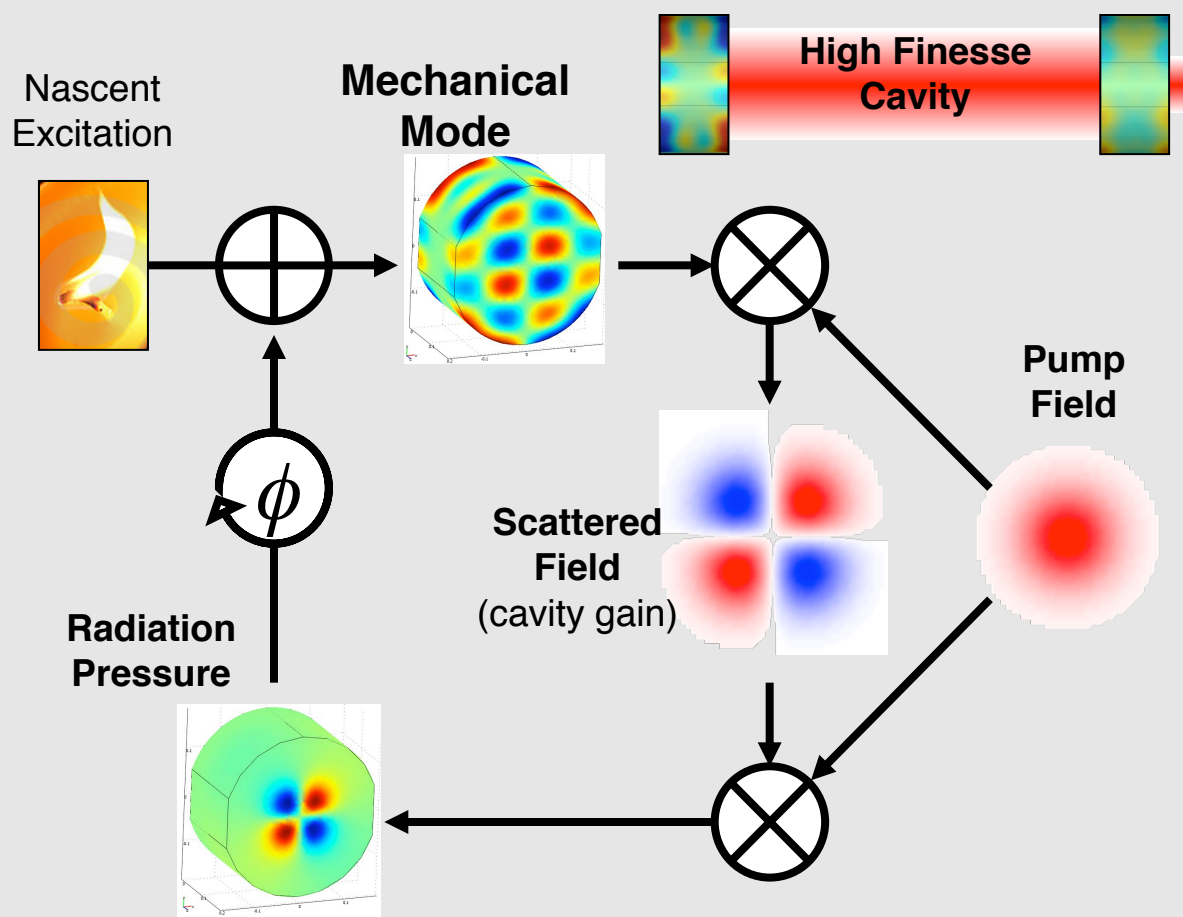
## Systems design: high power operation issues

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- **Operational complexities associated with increasing power**
  - » Enhanced LIGO serves as a stepping stone: operation achieved at 25 W into vacuum system
- **Excess absorption in the high-reflector coatings**
  - » Thermal Compensation System being designed to handle 2x specified coating absorption level
  - » Concern that contamination could go beyond that – see Dennis' talk
- **Parametric Instabilities**

## Parametric Instabilities

**Combination of high stored optical power and low mechanical loss could cause an instability:**



*Model predictions:*

A few – 10 modes per test mass could be unstable

Models assume very high acoustic mode Q-values:  
10-30 million

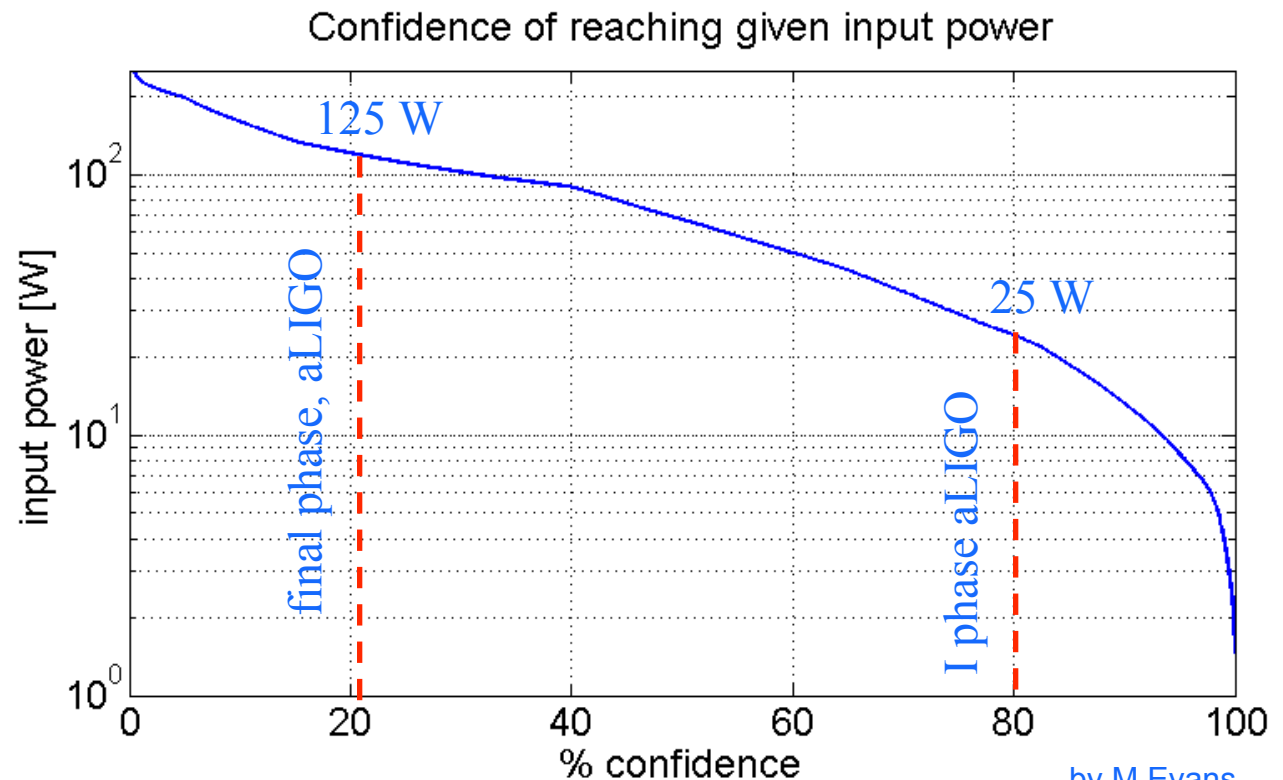
Best defense is to reduce the acoustic mode Q's



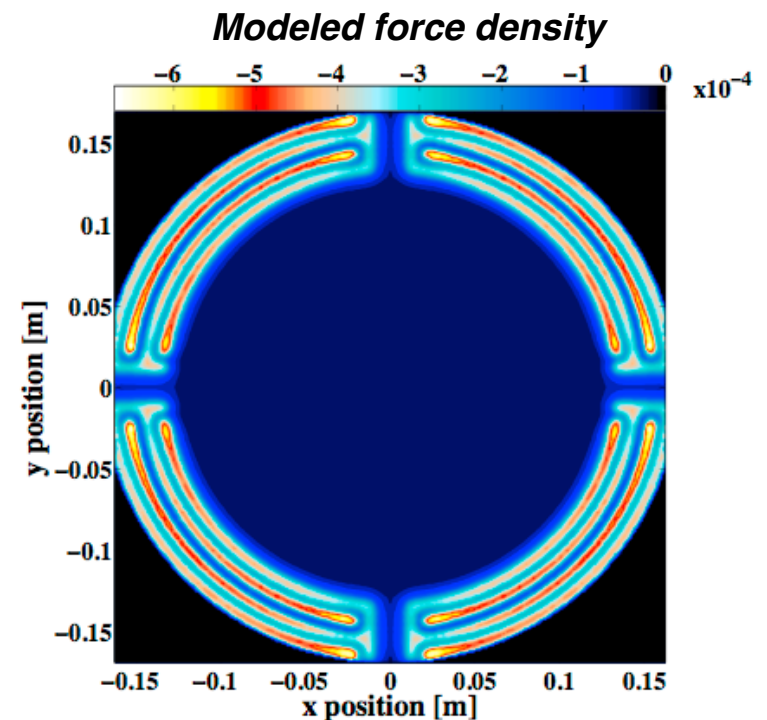
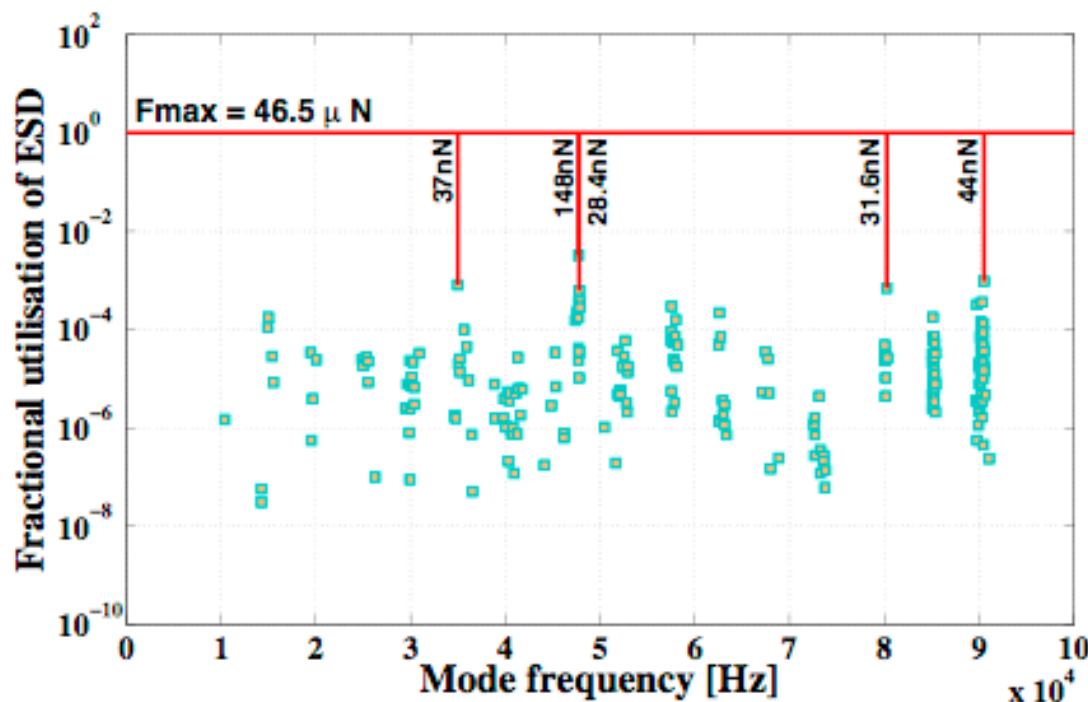
- High parametric gain relies on close frequency matching of acoustic & optical modes
  - » These frequencies not known well enough to accurately calculate PI

Monte Carlo simulation  
with parameters varied  
over their plausible ranges

Plot shows result of  
~100,000 trials

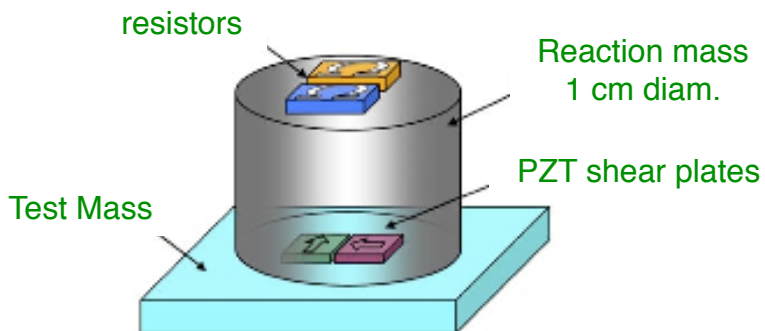


- Active damping using the electro-static actuators on the test masses
  - » FEA modeling of actuator force density & acoustic modes
  - » Calculate ESD force required to damp acoustic modes so that parametric gain is reduced to 0.1

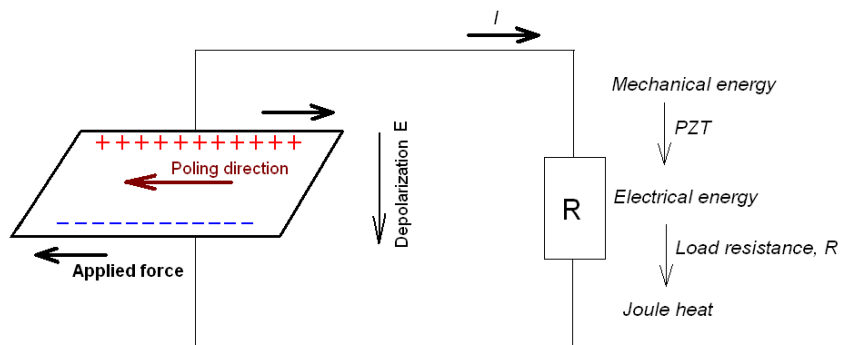


## Passive Acoustic Mode Damping

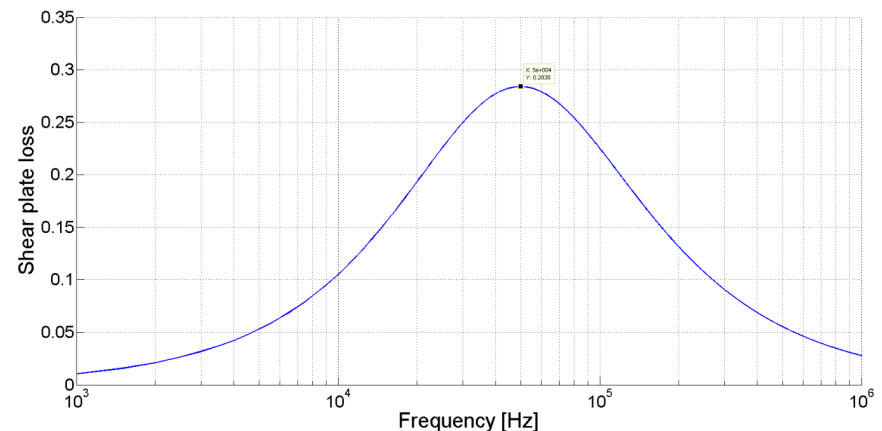
- **Add a few resonant mechanical dampers to the Test Mass**
  - » Resonant frequencies  $> 10$  kHz
  - » Damper resonances are fairly broad (not 'tuned' dampers)
  - » Mounted to the barrel of the optic



**AMD: Acoustic Mode Damper**  
Principal resonances designed to be between 10 – 60 kHz

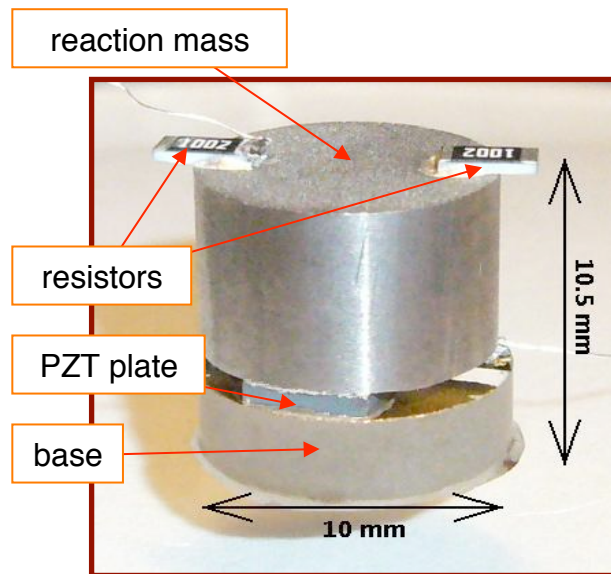


Shunted shear plate.

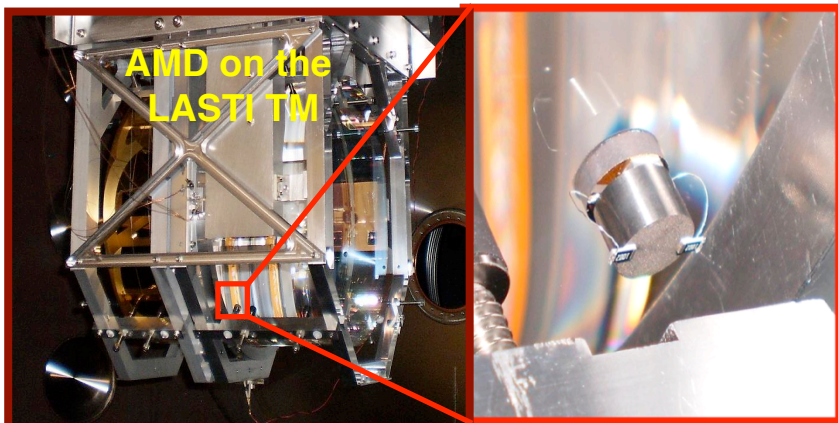


## Acoustic Mode Damper development

### AMD prototyped on LASTI's quad suspension



- Test Mass Q's are very high: **10-20 million** measured for a dozen modes
- AMD damps these by 1-2 orders of magnitude
- However, most of this damping due to something other than resistor dissipation: PZT material & epoxy; these would produce **excess thermal noise**
- Concept still viable if **lower loss PZTs and epoxy** used; currently researching better materials



## Summary of PI control strategy

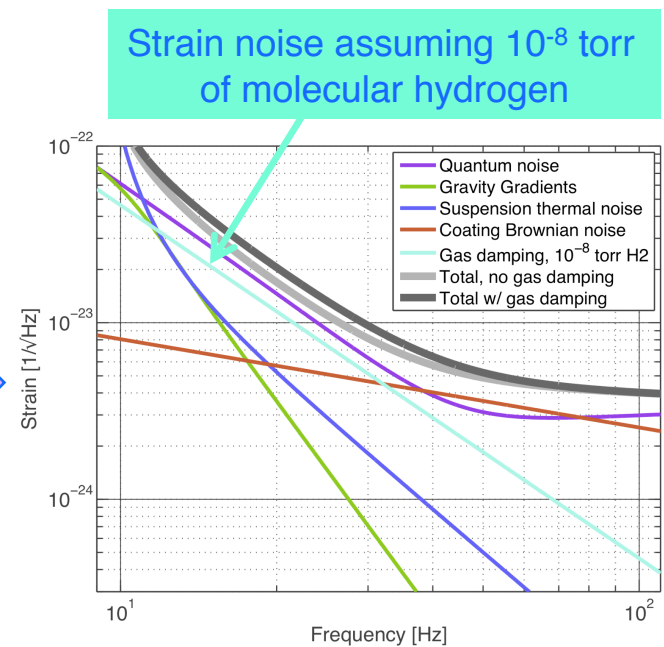
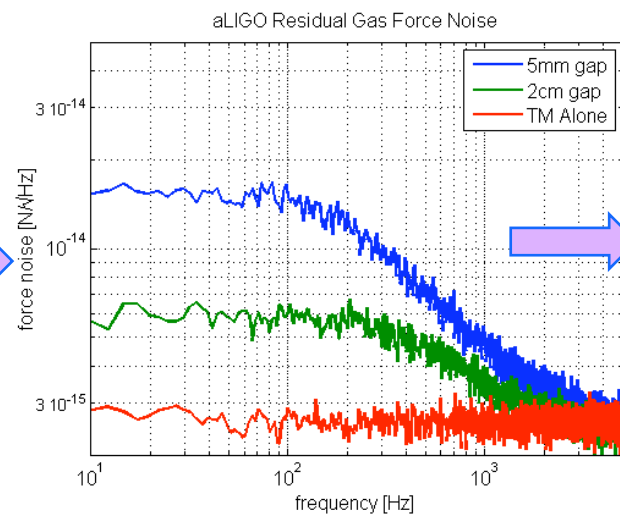
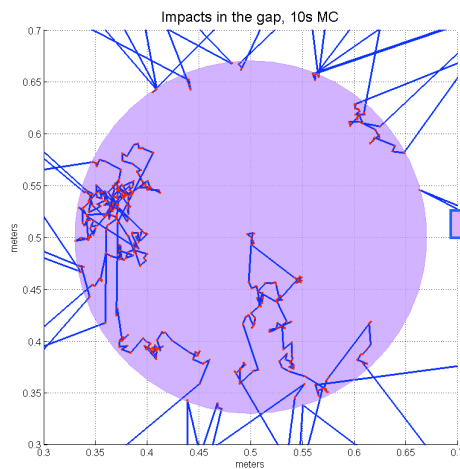
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- **Active damping with Electro-Static Actuators is currently the first option**
  - » Feasible if 1 or 2 modes per test mass are unstable; beyond that it gets complicated
- **Acoustic Mode Dampers: better approach if we had a low noise AMD in hand**
  - » Continued R&D on low noise AMDs
  - » Possible retrofit on installed Test Masses

## System design: squeezed-film gas damping

- **Residual gas in the gap between Test Mass and Reaction Mass produces increased damping of the TM pendulum motion**
  - » Increased damping means higher suspension thermal noise, could be important for frequencies below about 50 Hz
  - » Monte Carlo simulations following gas particles in the gap used to calculate force noise

Simulation of a gas particle interacting with the TM-RM gap



## Mitigation of squeezed-film damping

- **Gap between ITM & CP was increased from 5 mm to 2 cm**
  - » Reduced the thickness of the CP
  - » Minor changes to accommodate in the quad suspensions
  - » ESD force reduced as a consequence, but there was margin to spare for the ITMs
  - » Force noise reduced by factor of 2.6
- **ETM-ERM gap is a different issue**
  - » Rely on ESD force for lock acquisition & global control: don't want to reduce the force before we get experience with what we really need
  - » New reaction mass geometries could reduce damping and retain ESD force
  - » Solution could be a combination of new ERMs and more pumping; will be taken when we know more about required force & chamber pressure

